



***Integrity ★ Service ★ Excellence***

# **Ultrashort Pulse (USP) Laser – Matter Interactions**

**5 MAR 2013**

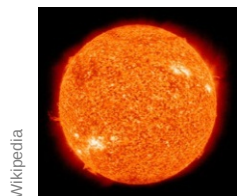
**Dr. Riq Parra  
Program Officer  
AFOSR/RTB**

**Air Force Research Laboratory**

| Report Documentation Page                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                              |                                    |                                     |                                                                  | Form Approved<br>OMB No. 0704-0188                  |                                    |
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| 1. REPORT DATE<br><b>05 MAR 2013</b>                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                   |                                    | 2. REPORT TYPE                      |                                                                  | 3. DATES COVERED<br><b>00-00-2013 to 00-00-2013</b> |                                    |
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| 15. SUBJECT TERMS                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                      |                                    |                                     |                                                                  |                                                     |                                    |
| 16. SECURITY CLASSIFICATION OF:                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                        |                                    |                                     | 17. LIMITATION OF<br>ABSTRACT<br><b>Same as<br/>Report (SAR)</b> | 18. NUMBER<br>OF PAGES<br><b>45</b>                 | 19a. NAME OF<br>RESPONSIBLE PERSON |
| a. REPORT<br><b>unclassified</b>                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                       | b. ABSTRACT<br><b>unclassified</b> | c. THIS PAGE<br><b>unclassified</b> |                                                                  |                                                     |                                    |



# Modelocked femtosecond lasers



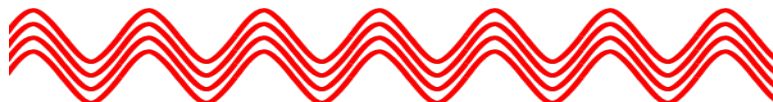
Sunlight



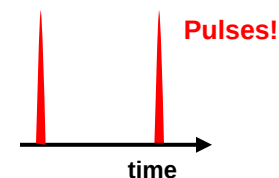
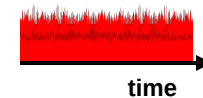
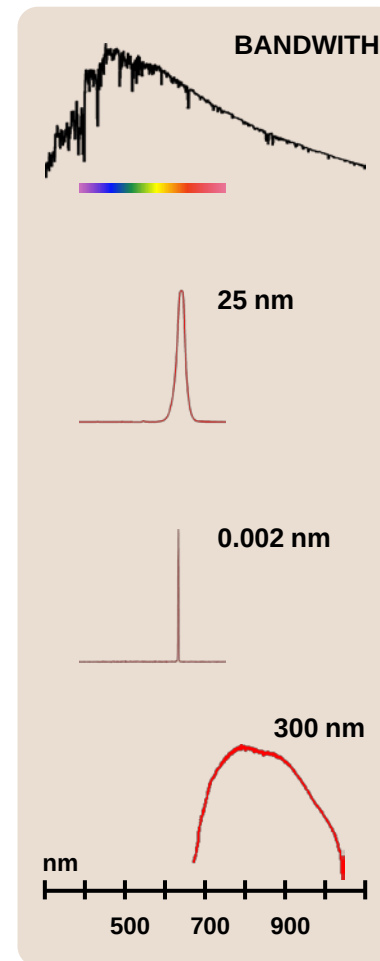
Light Emitting Diode



He-Ne cw laser

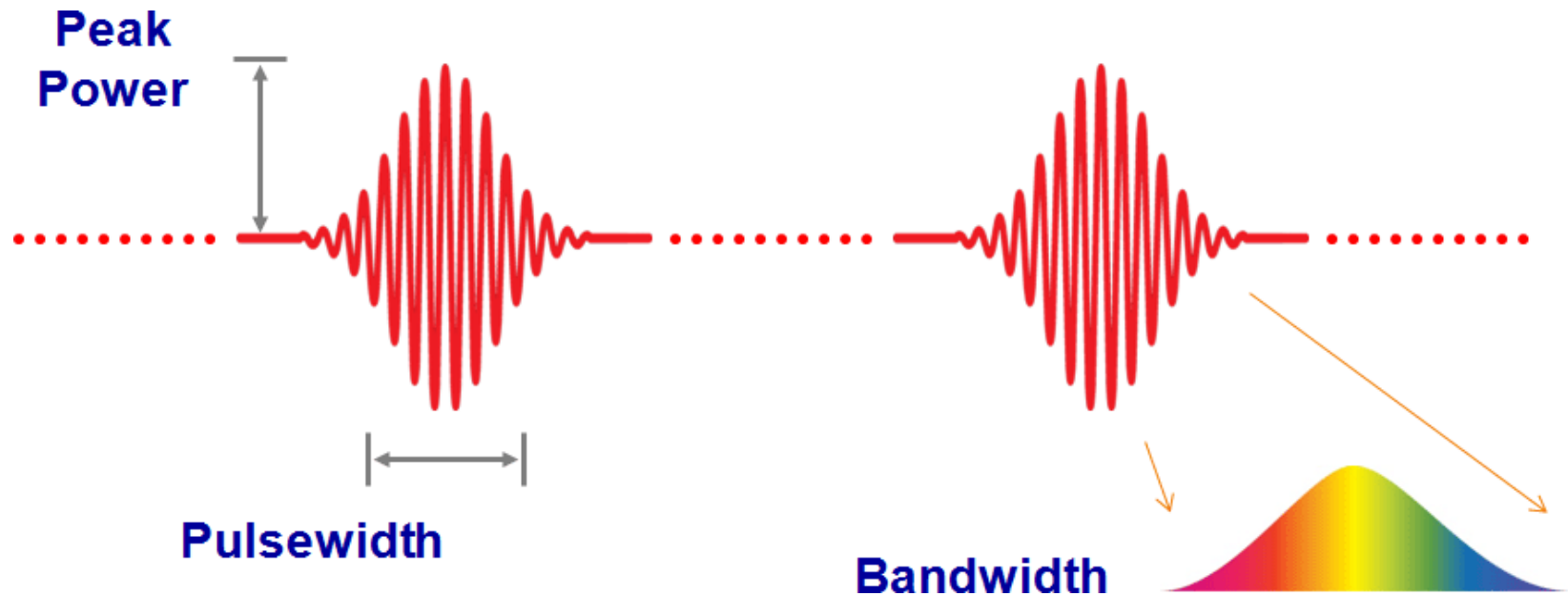


Ti:Sapphire modelocked fs laser





# 2013 AFOSR SPRING REVIEW 3001O PORTFOLIO OVERVIEW



- The program aims to understand and control light sources exhibiting extreme bandwidth, peak power and temporal characteristics.
- Portfolio sub-areas: optical frequency combs, high-field science, attosecond physics.



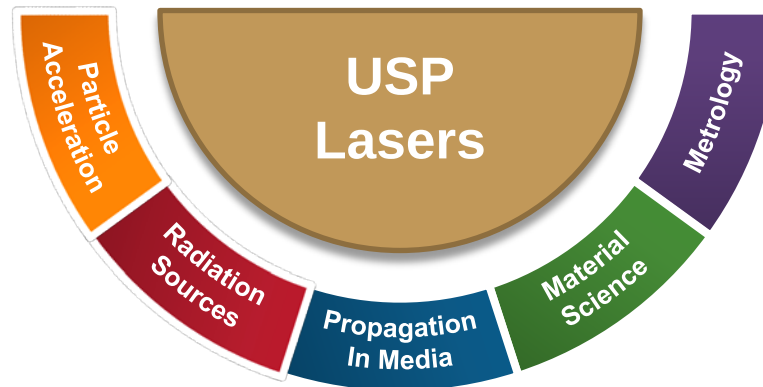
# Applications of USP Lasers



## Particle Acceleration

*ultrahigh electric field gradients*

- Table-top GeV electron accelerators
- MeV ion sources for imaging
- Isotope production
- Hadron tumor therapy
- Proton-based fast ignition



## Metrology

*stabilized, ultra-wide bandwidth*

- Ultra-stable freq sources
- Optical waveform synthesis
- High precision spectroscopy
- Frequency/time transfer
- High-capacity comms
- Coherent LIDAR
- Optical clocks
- Calibration

## Secondary Radiation Sources

*generation of particle & photons*

- High power THz generation
- Extreme ultraviolet lithography
- Biological soft x-ray microscopy
- Non-destructive evaluation
- Medical imaging/therapy

## Propagation in media

*self-channeling*

- Remote sensing
- Remote tagging
- Directed energy
- Electronic warfare
- Countermeasures
- Advanced sonar

## Material Science

*ultrashort, high peak power*

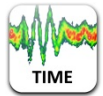
- Surgery
- Chemical analysis (LIBS)
- Surface property modification
- Non-equilibrium ablation
- Micromachining
- Ultrafast photochemistry
- Attochemistry



# Outline



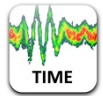
— Microresonator-based optical frequency combs



— High peak power, ultrashort pulse laser processing of materials



— Extreme ultraviolet (EUV) comb spectroscopy



— High harmonic interferometry



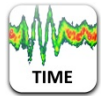
— Relativistic optics



# Outline



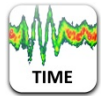
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— High peak power, ultrashort pulse laser processing of materials



— Extreme ultraviolet (EUV) comb spectroscopy



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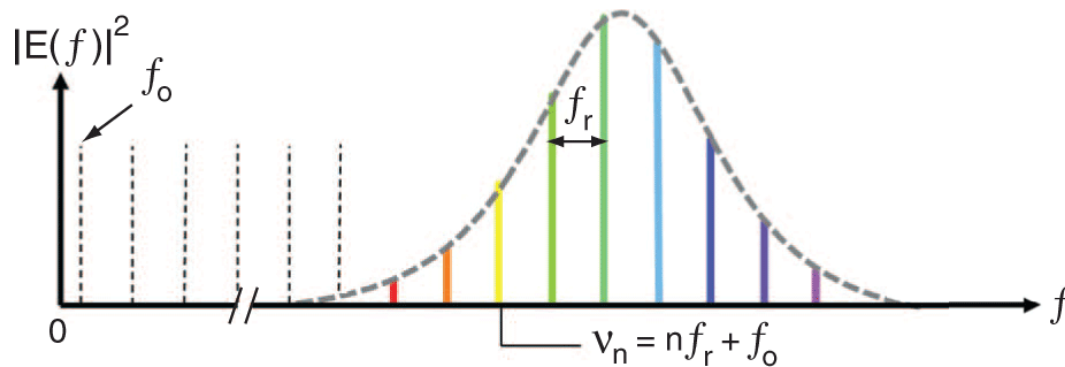
— Relativistic optics



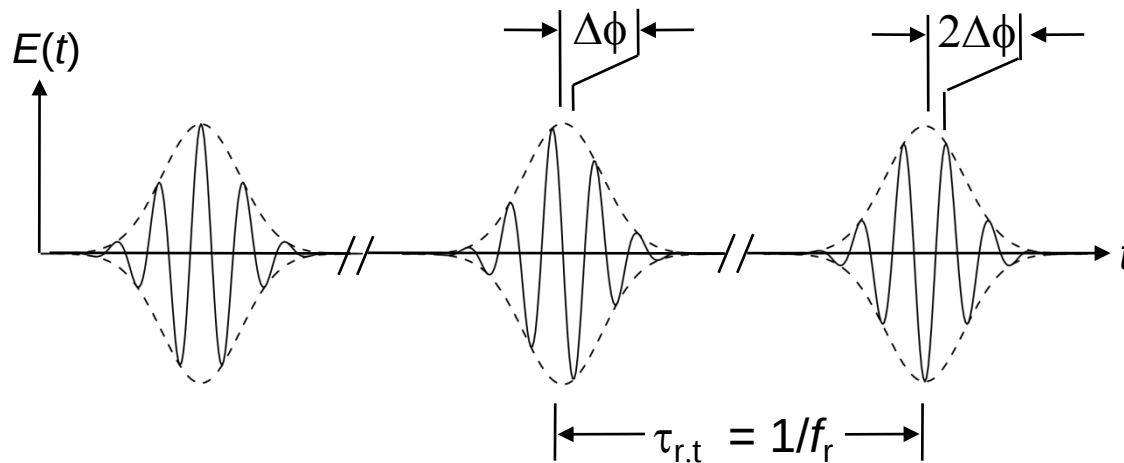
# Optical frequency combs: Frequency & time domains



**Frequency  
domain**

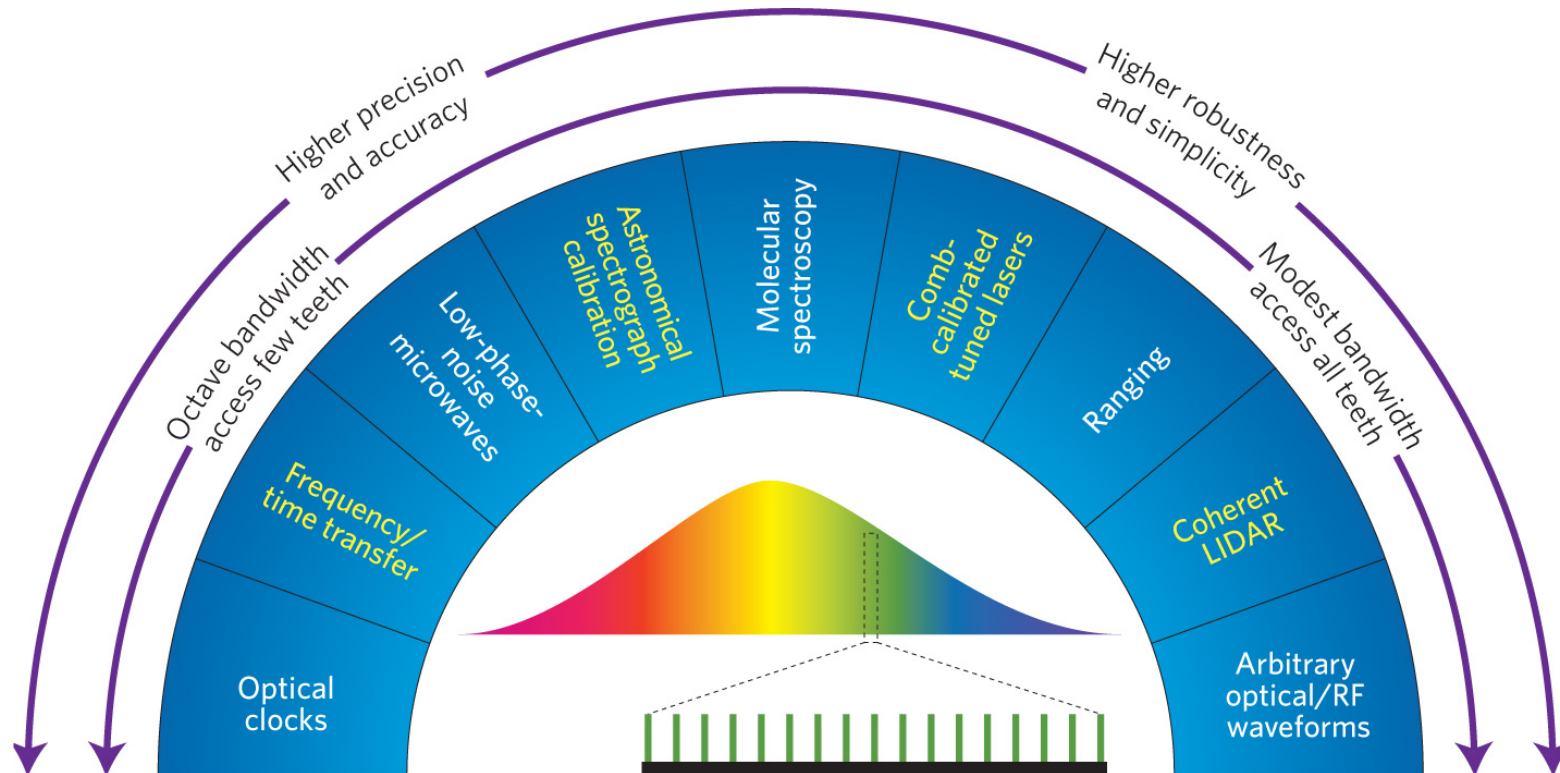


**Time  
domain**





# Metrological applications of optical frequency combs



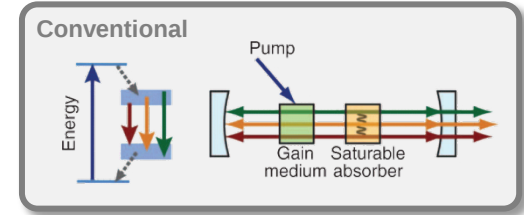
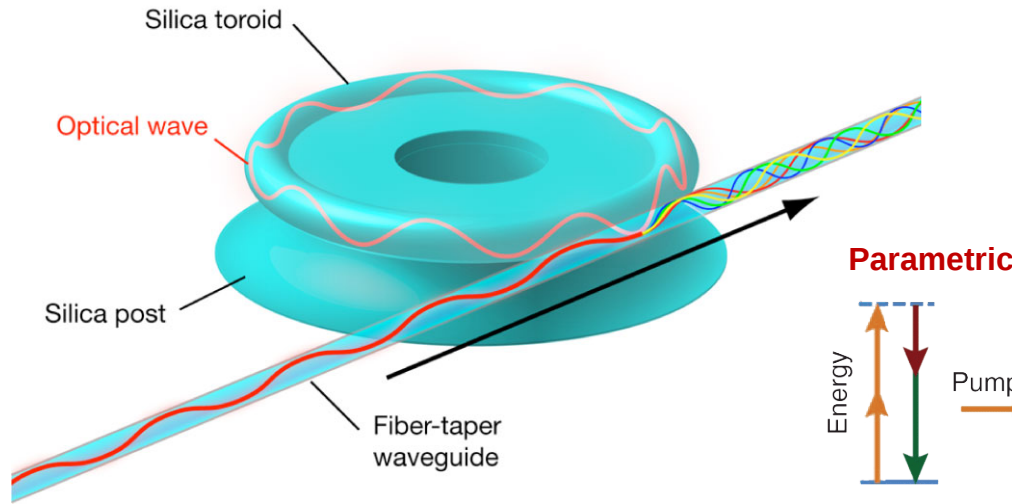


# Combs in monolithic microresonators

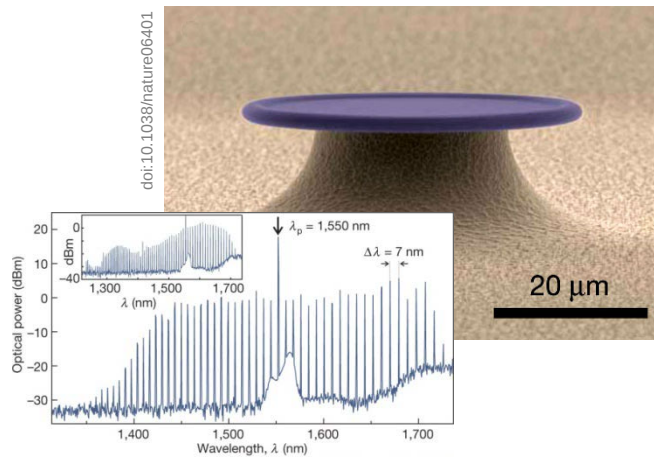


Source: Kippenberg et al., Science (2011)

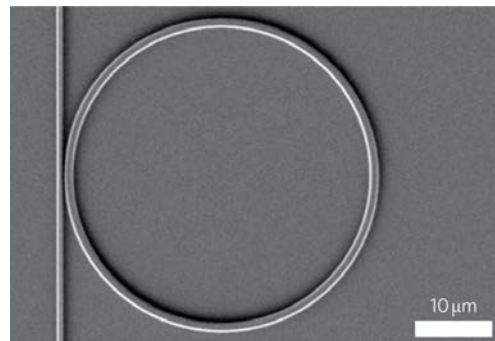
Source: Braje, Physics 3, 75 (2010)



Silica toroids

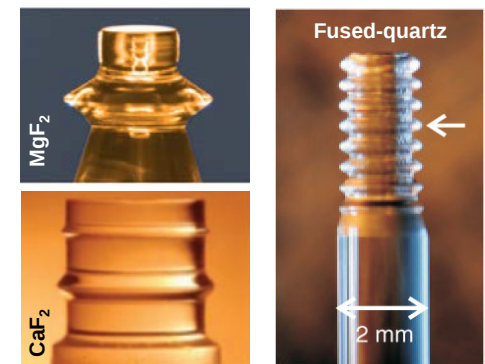


Silicon nitride microrings



doi: 10.1038/nphoton.2009.259

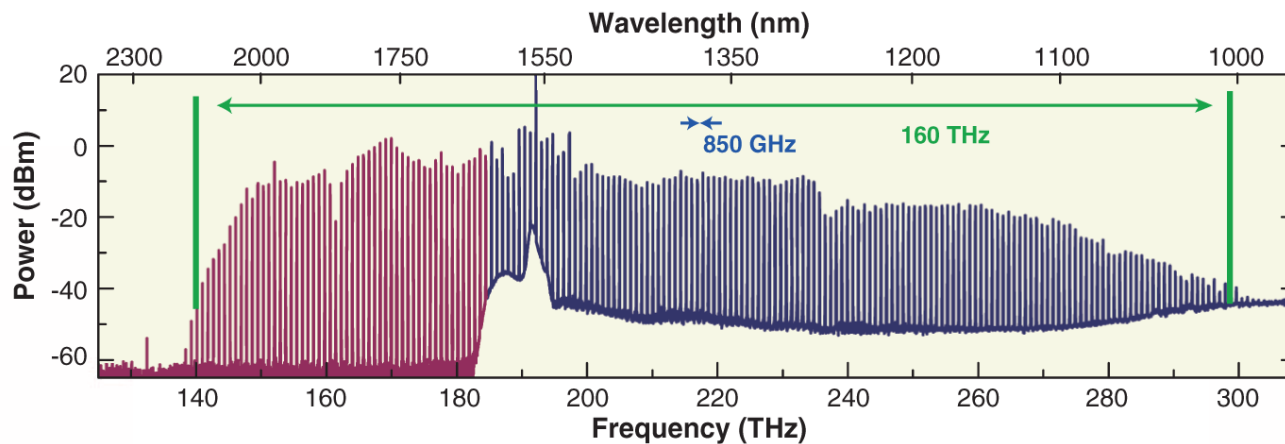
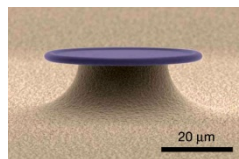
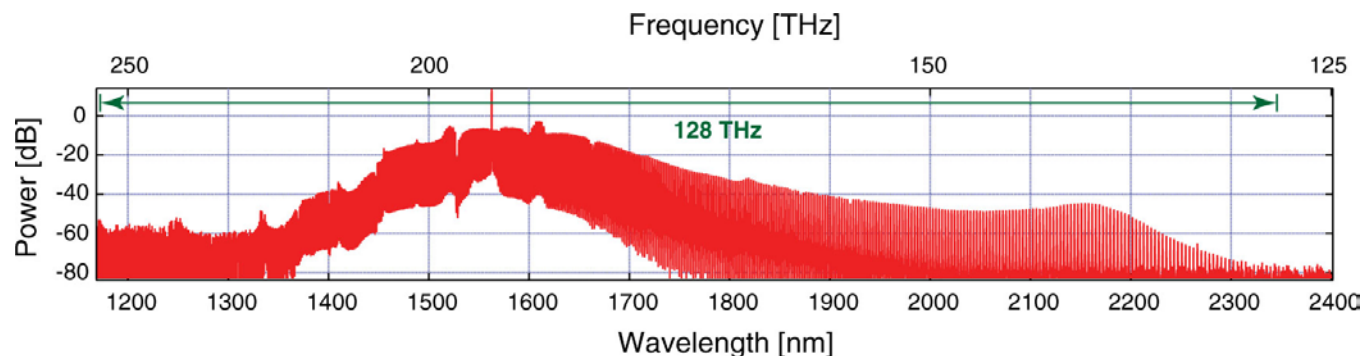
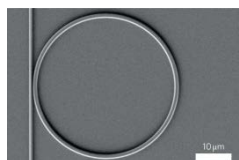
High-Q mm crystalline resonators



top left doi: 10.1038/nphoton.2012.127  
right doi: 10.1103/physreva.84.053833  
bottom left doi: 10.1103/physrevlett.101.093902

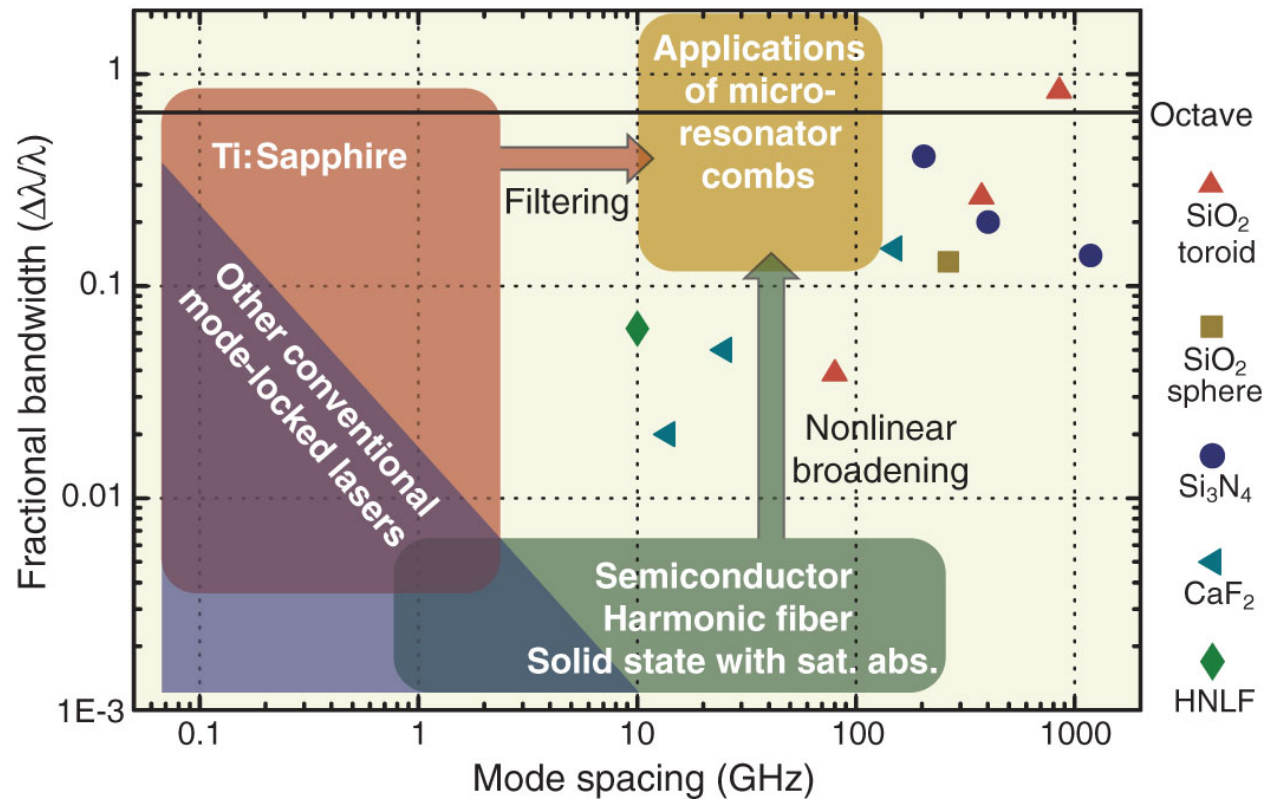
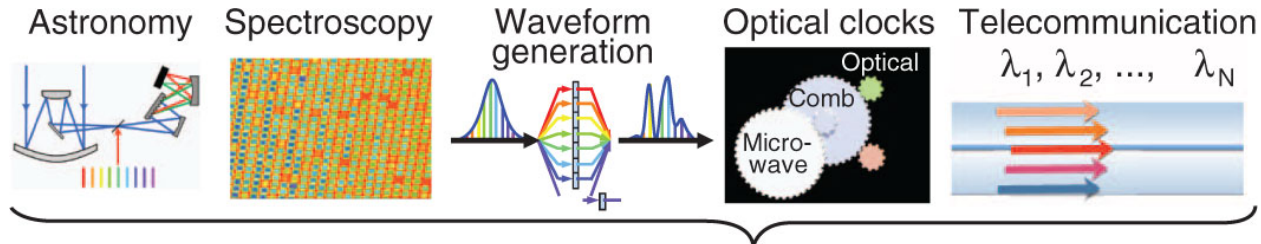


# Octave spanning bandwidths



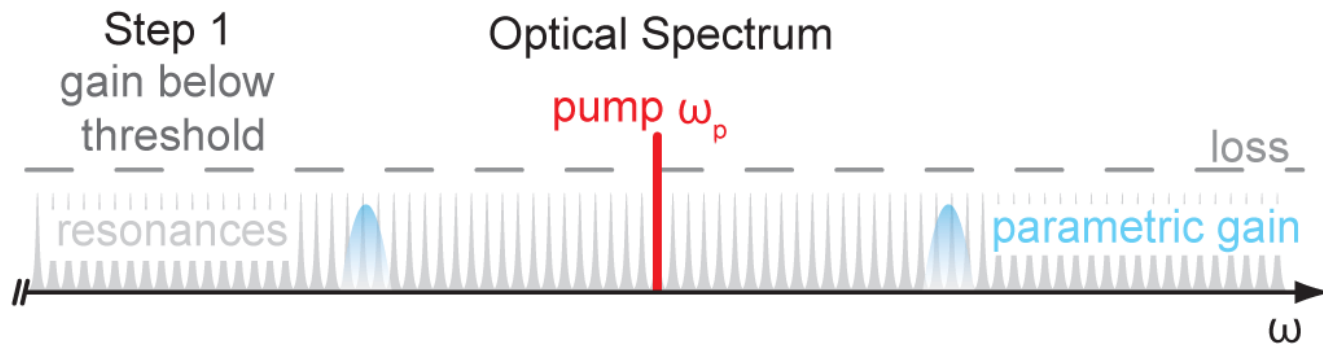


# Why microresonators?



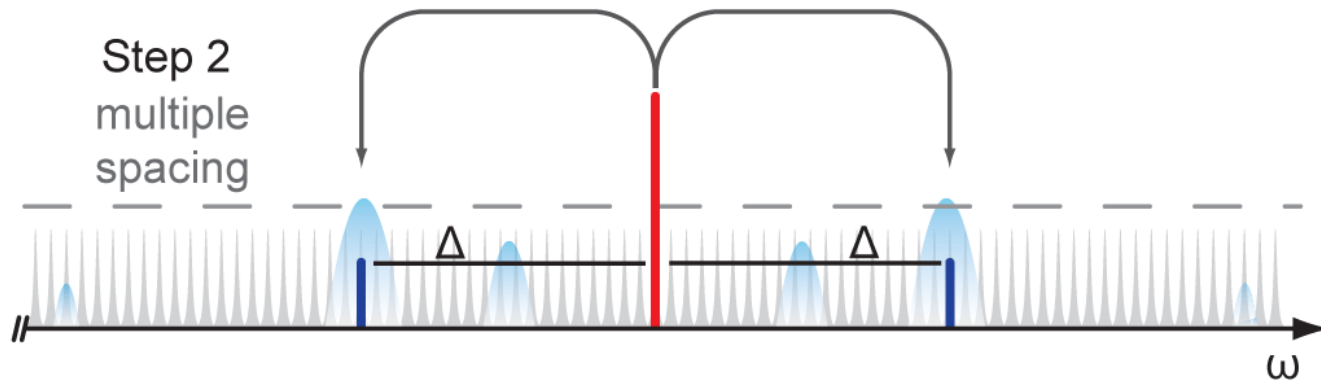


# Comb generation dynamics



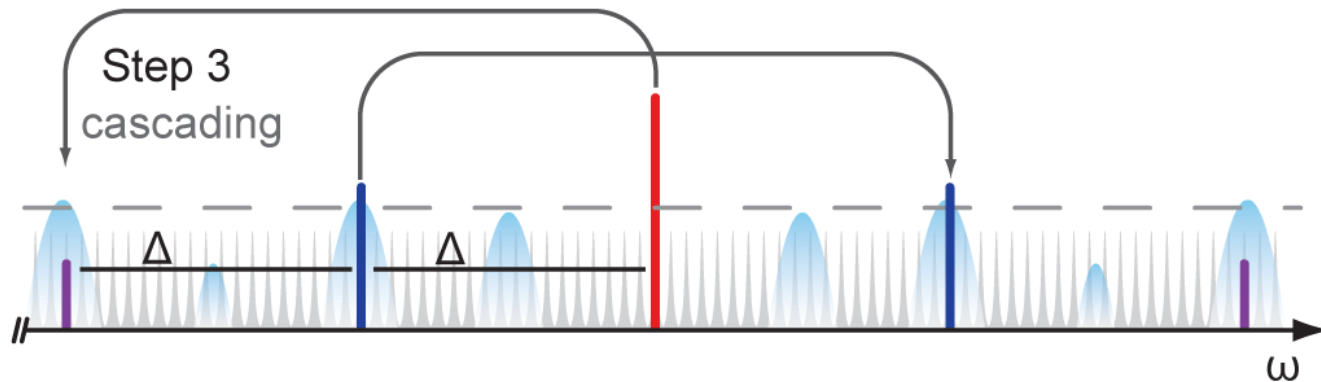


# Comb generation dynamics



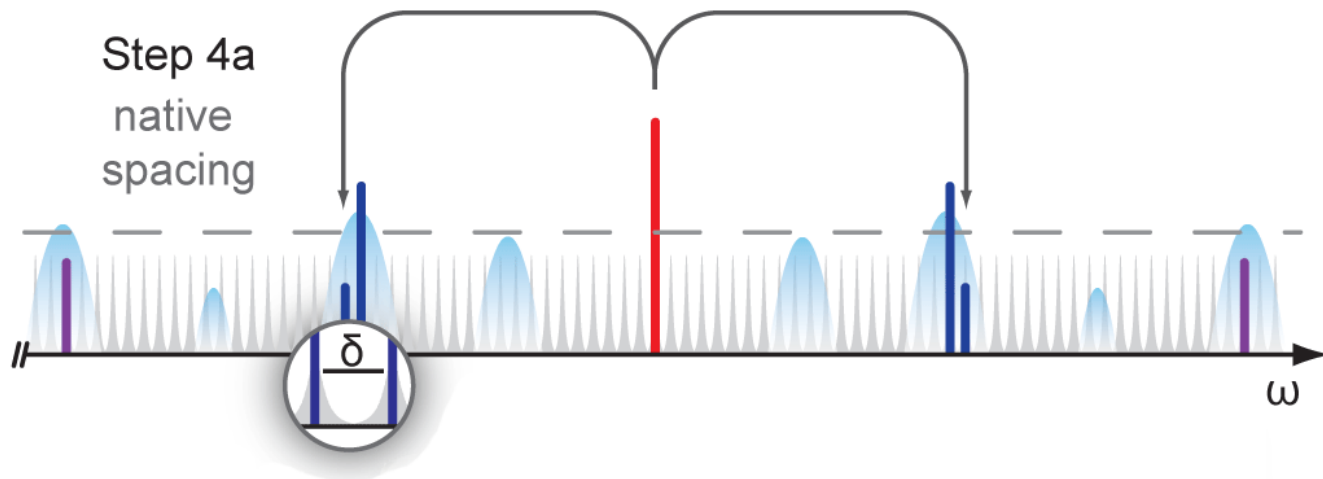


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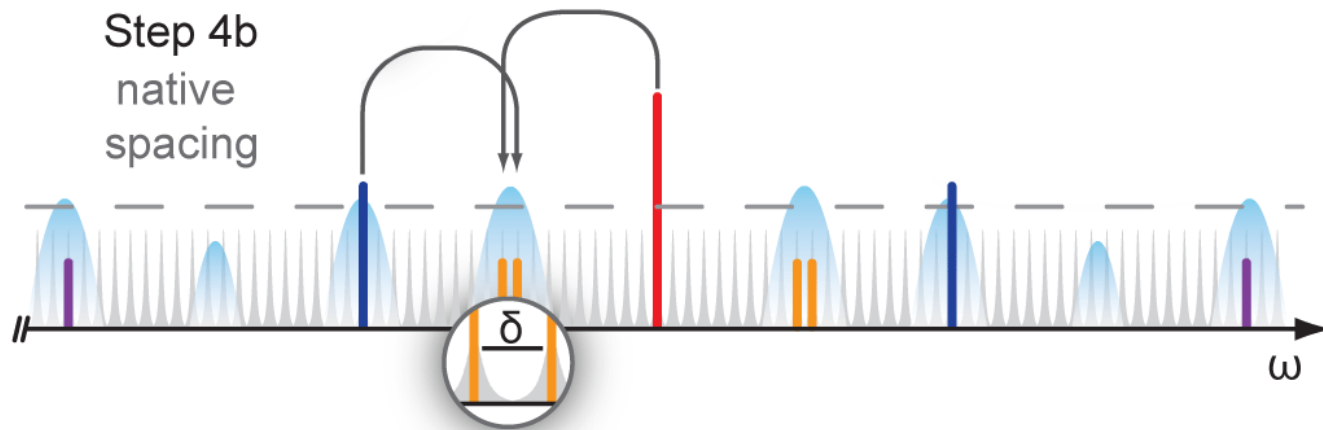


# Comb generation dynamics



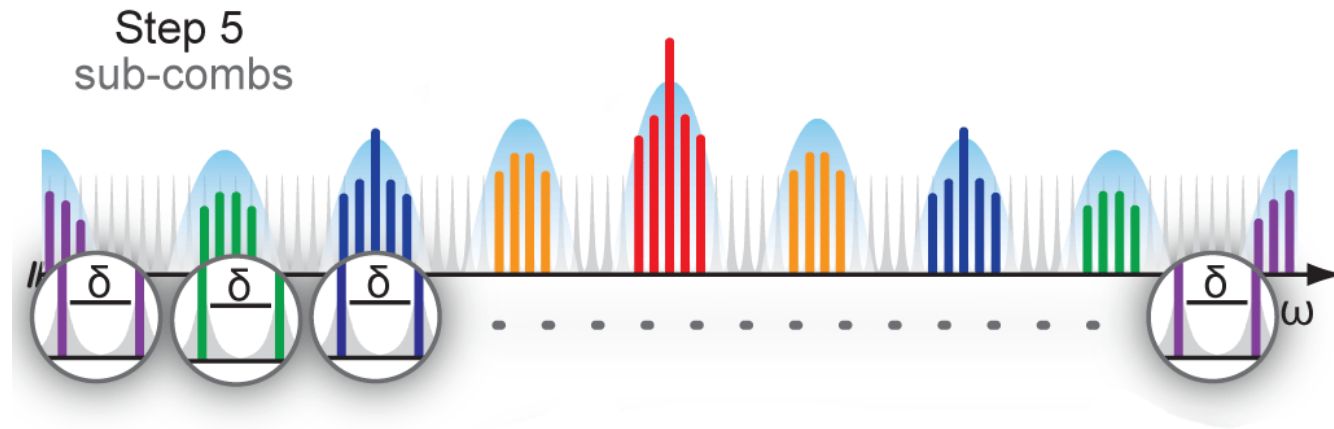


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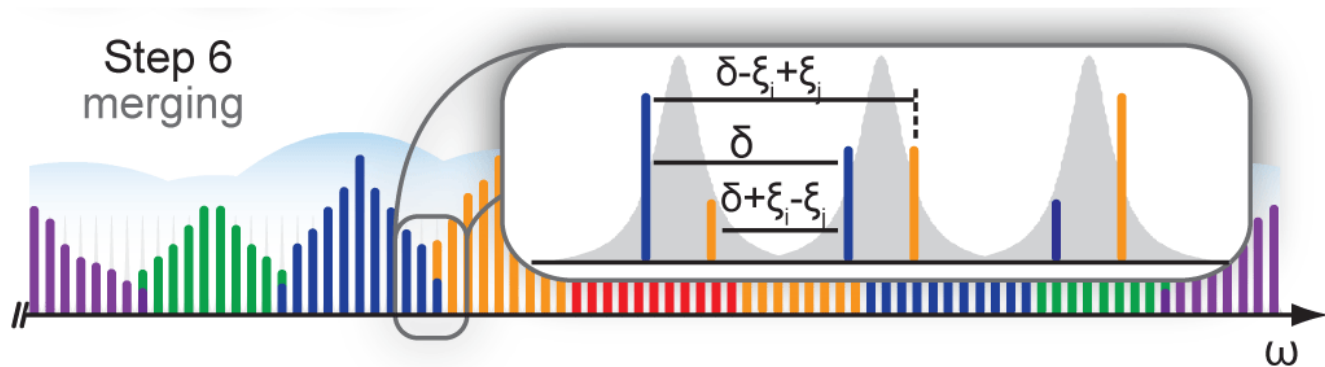


# Comb generation dynamics





# Comb generation dynamics





# (FY12 BRI) Microresonator-based optical frequency combs



S. Diddams  
NIST



Q. Lin  
UNIVERSITY of ROCHESTER



A. Gaeta  
Cornell



A. Matsko  
OEwaves

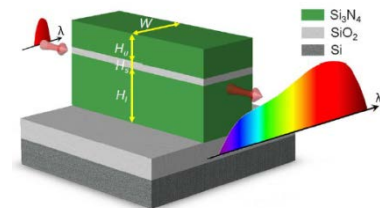
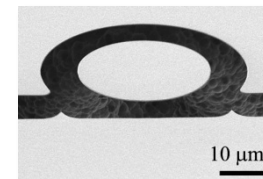


A. Weiner  
PURDUE UNIVERSITY



A. Willner  
USC Optical Communications Laboratory

- Initiative aimed at exploring the fundamental physics of microresonator comb generation.
- Six efforts exploring:
  - Spatio-temporal field mapping and control
  - Silicon-carbide microdisks
  - Silicon nitride resonators
  - Mid-IR microresonators
  - Time domain characterization
  - Dispersion tailoring via slotted waveguides



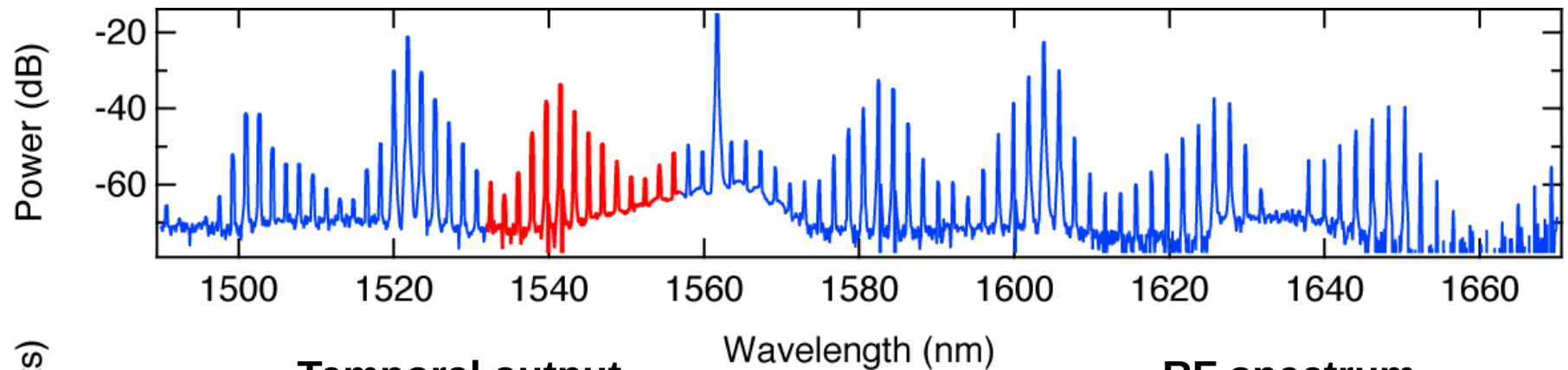


# Temporal and Spectral Comb Generation Dynamics

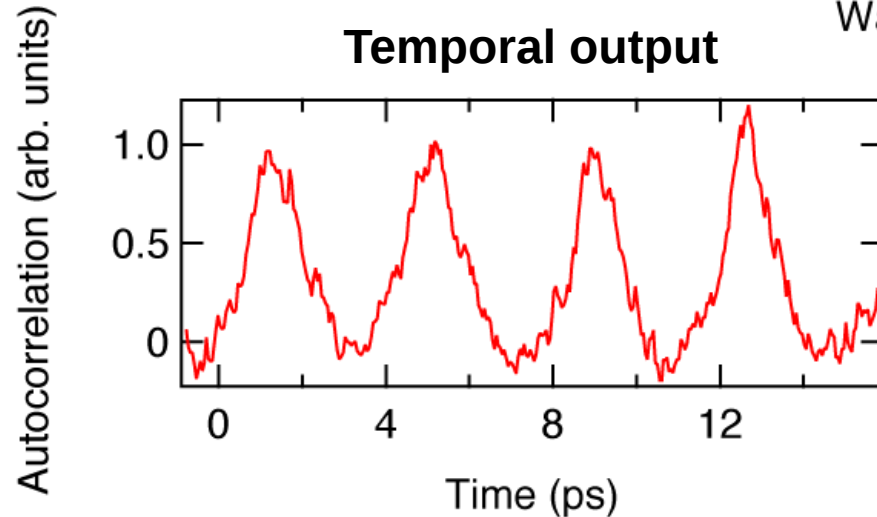


PI: Alex Gaeta, Cornell

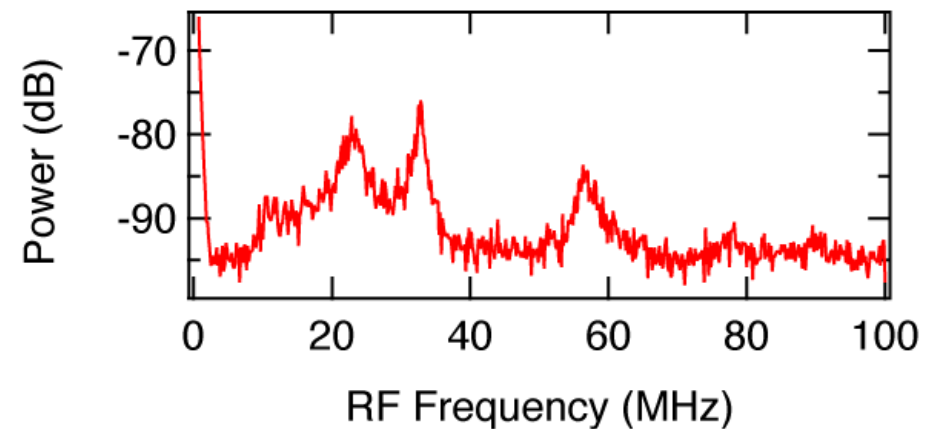
Optical spectrum



Temporal output



RF spectrum



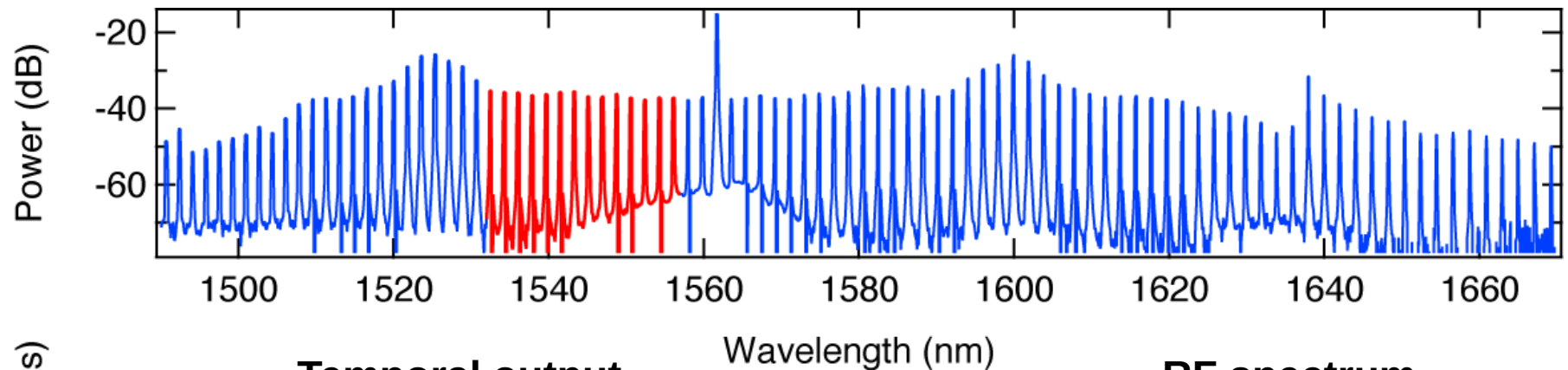


# Temporal and Spectral Comb Generation Dynamics

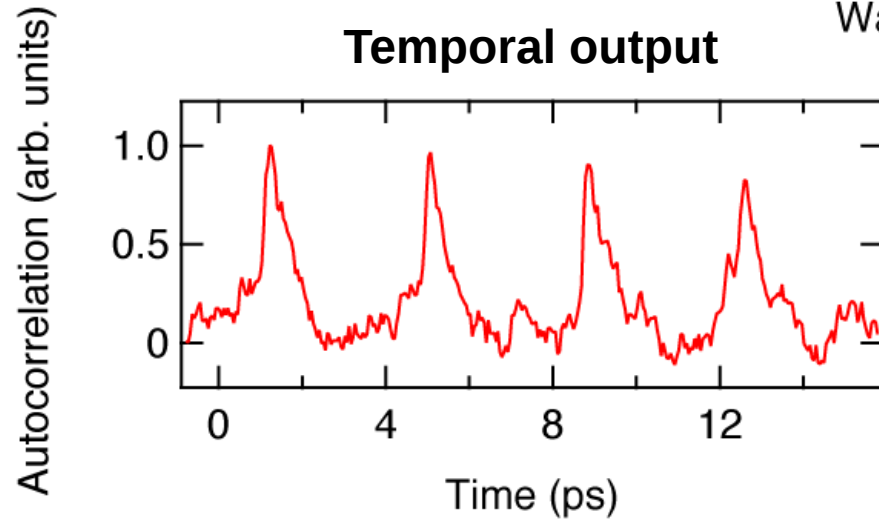


PI: Alex Gaeta, Cornell

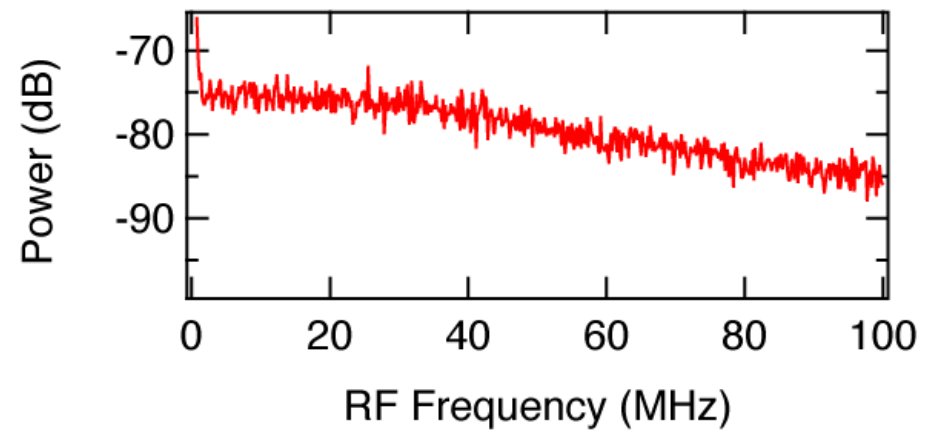
Optical spectrum



Temporal output



RF spectrum



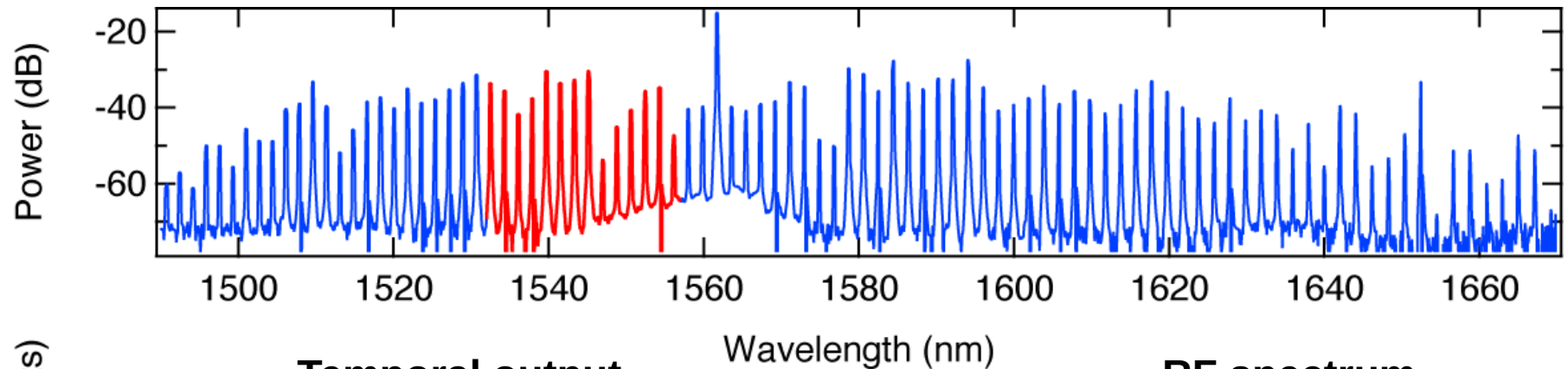


# Temporal and Spectral Comb Generation Dynamics

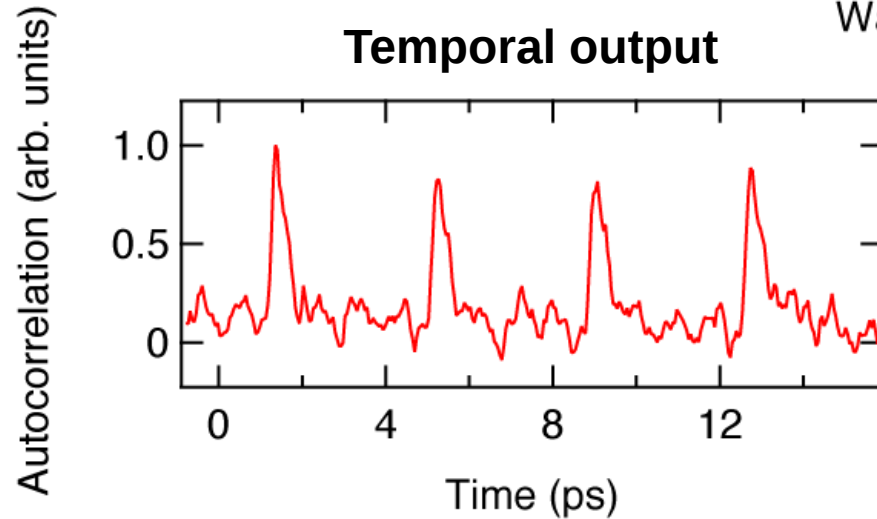


PI: Alex Gaeta, Cornell

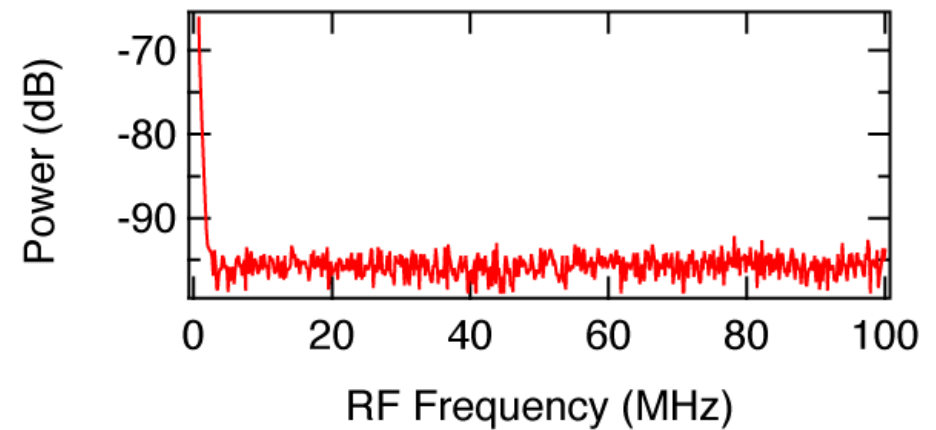
Optical spectrum



Temporal output



RF spectrum



Transition to modelocking?

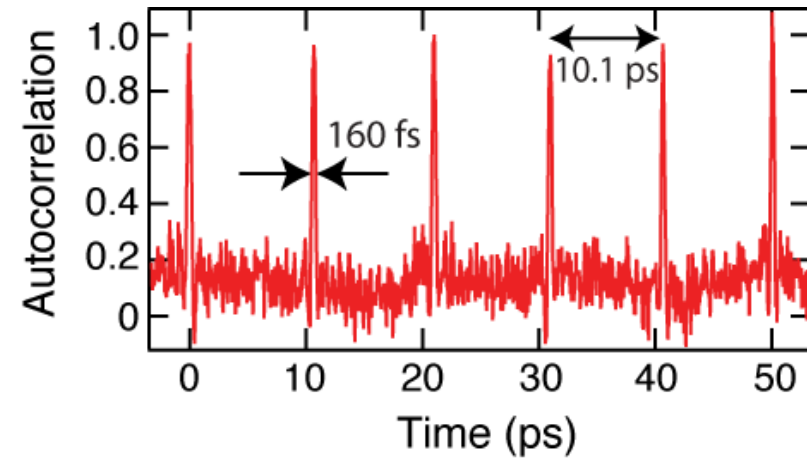
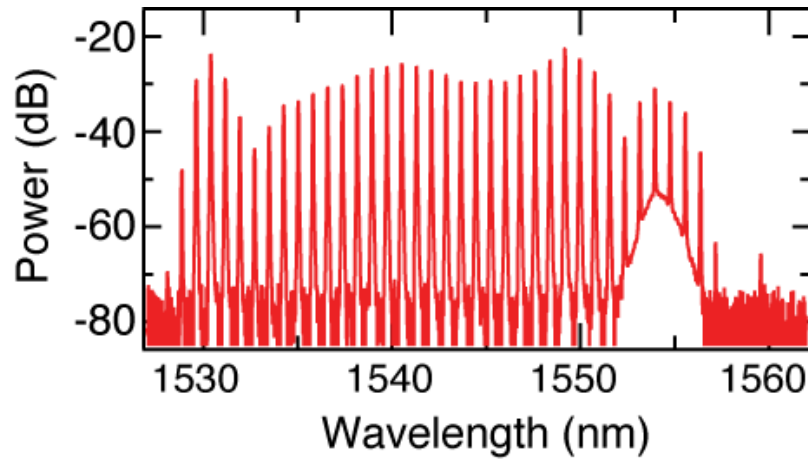




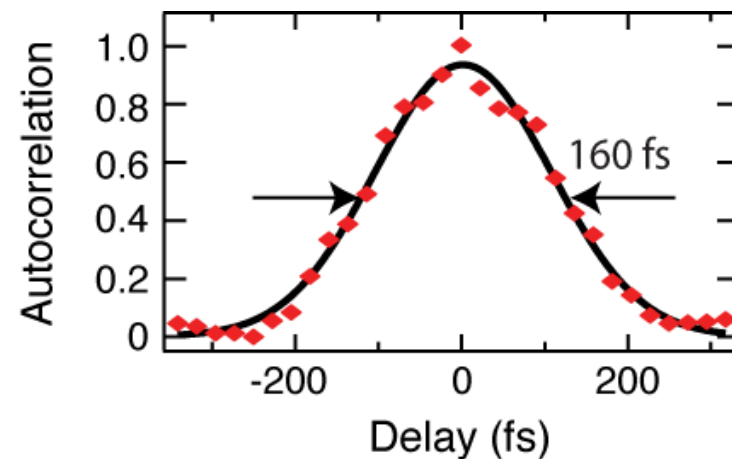
# Ultrashort Pulses at 99 GHz



PI: Alex Gaeta, Cornell



- 99-GHz repetition rate
- 160-fs pulses

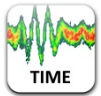




# Outline



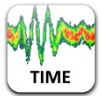
— Microresonator-based optical frequency combs



— **High peak power, ultrashort pulse laser processing of materials**



— Extreme ultraviolet (EUV) comb spectroscopy



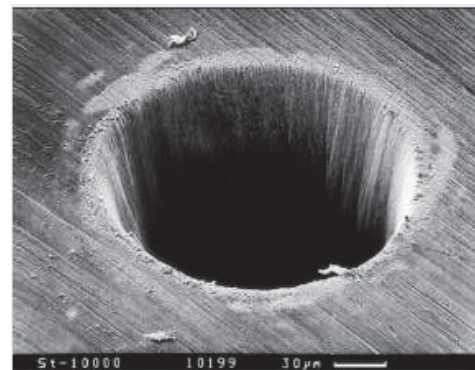
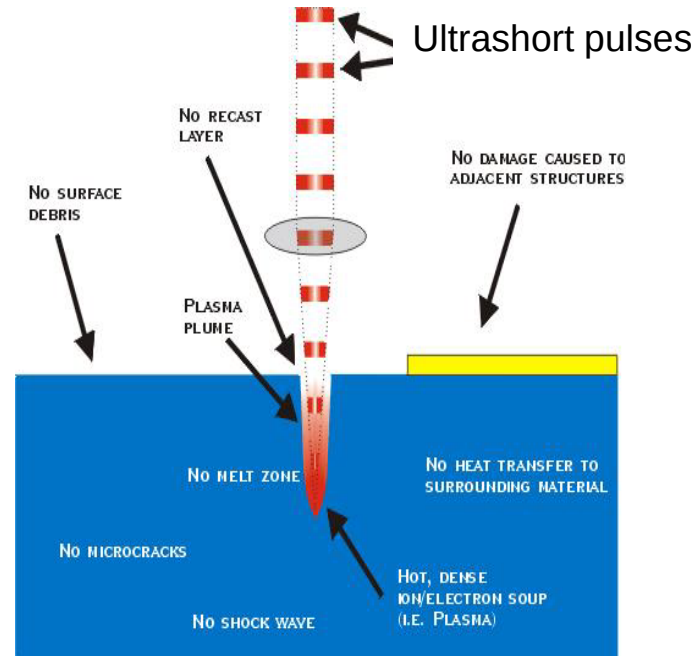
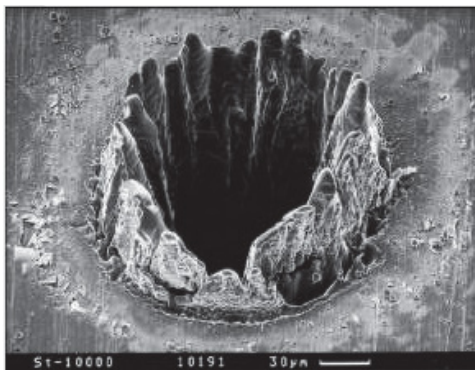
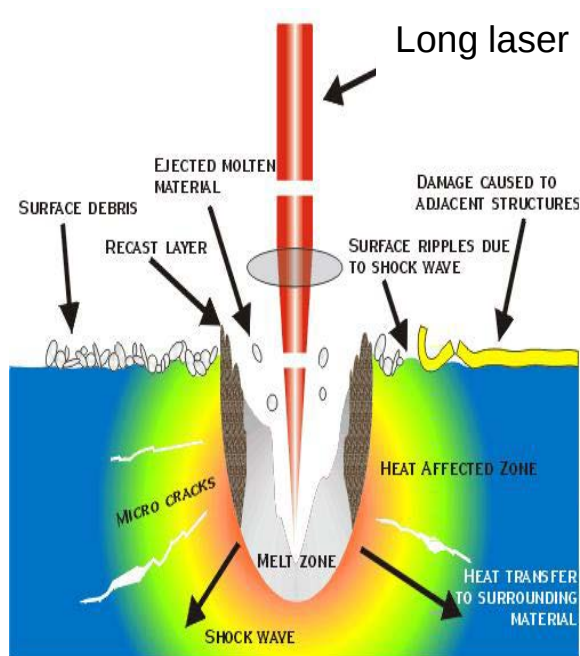
— High harmonic interferometry



— Relativistic optics



# Long laser pulse damages adjacent structures Ultrashort pulses → no collateral damage

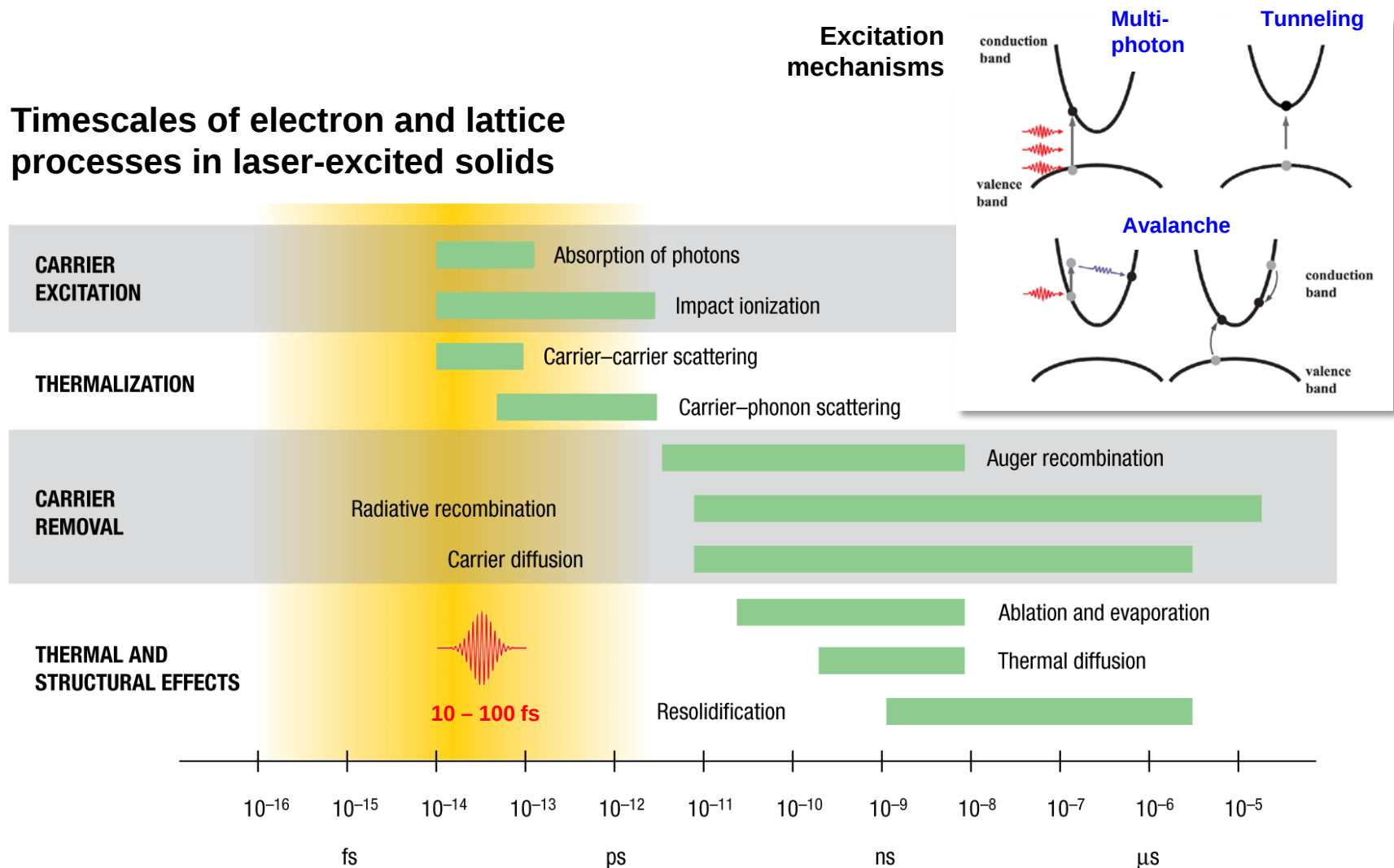




# Time-dependent processes in materials



## Timescales of electron and lattice processes in laser-excited solids



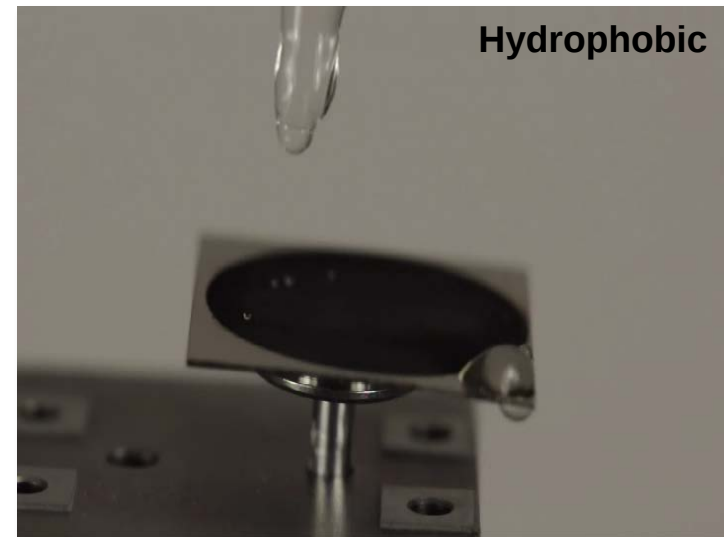
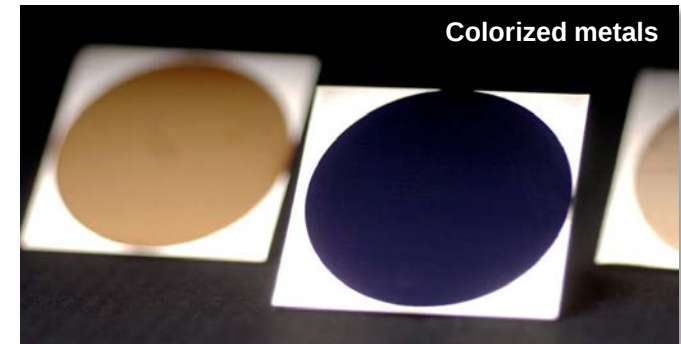


# High peak power, ultrashort pulse laser processing of materials



PI: Chunlei Guo, U of Rochester

- Ultrashort laser pulses open up novel possibilities and mechanisms for laser-solid interactions.
- Demonstrated femtosecond laser processing and surface texturing techniques to engineer surface structures & properties (e.g. darkened & colored metals, hydrophilic & hydrophobic surfaces).

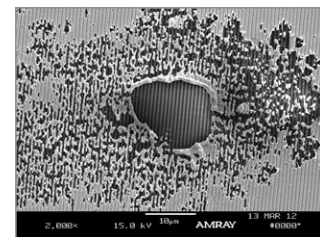
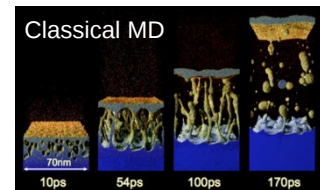




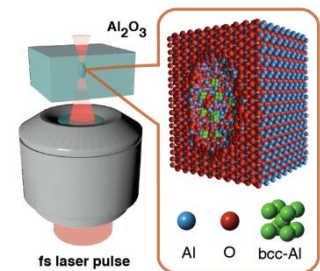
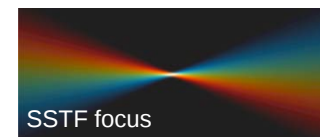
# (FY13 BRI) High peak power, ultrashort pulse laser processing of materials



- Initiative aimed at developing a fundamental understanding of intense field laser ablation/damage in the femtosecond regime.
- Three multi-PI efforts exploring:
  - Dynamics of ionization
  - Fundamental dynamics of laser ablation
  - Defect states in multi-pulse interaction
  - Effect of structures on laser damage
  - First principle-based models, non-adiabatic quantum MD, classical MD
  - Vary  $\lambda = 400 \text{ nm} - 4 \text{ }\mu\text{m}$ ,  $\tau = 5 - 1000 \text{ fs}$
  - Complex beam shapes (Bessel, Airy, vortex, SSTF beams)
  - Novel laser-matter interaction geometries (confined microexplosions, SSTF excitation, few-cycle pulses)



Gratings





# Outline



— Microresonator-based optical frequency combs



— High peak power, ultrashort pulse laser processing of materials



— **Extreme ultraviolet (EUV) comb spectroscopy**



— High harmonic interferometry



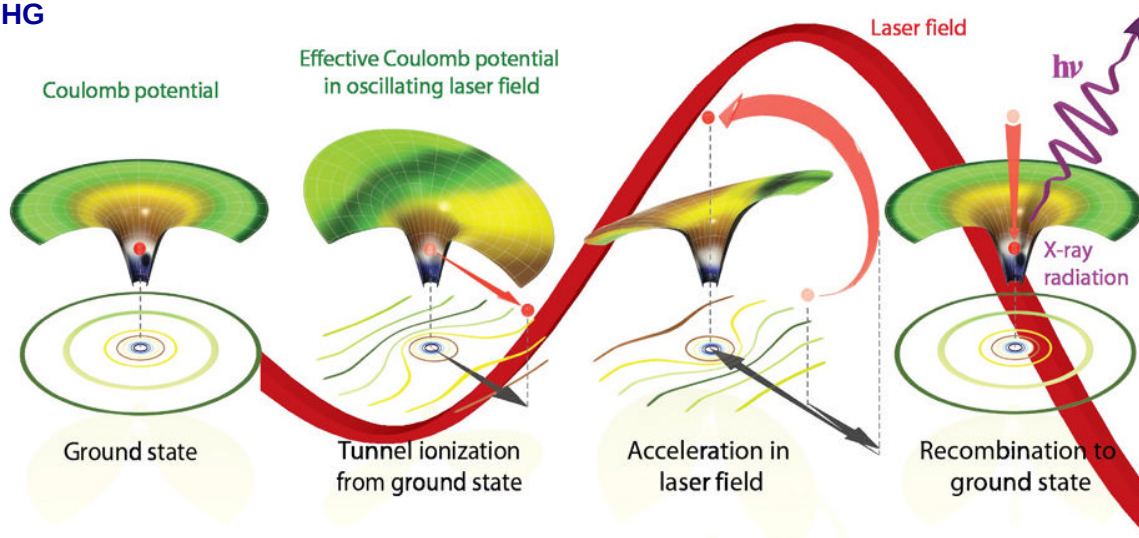
— Relativistic optics



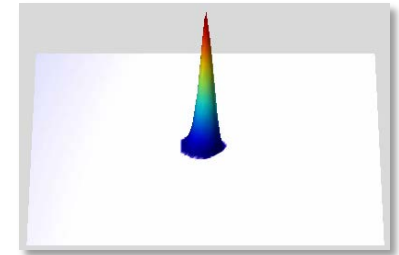
# High Harmonic Generation (HHG)



## Microscopic single-atom physics of HHG

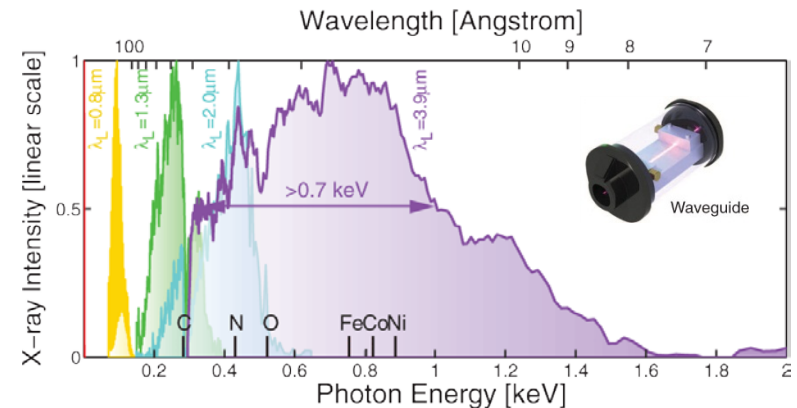
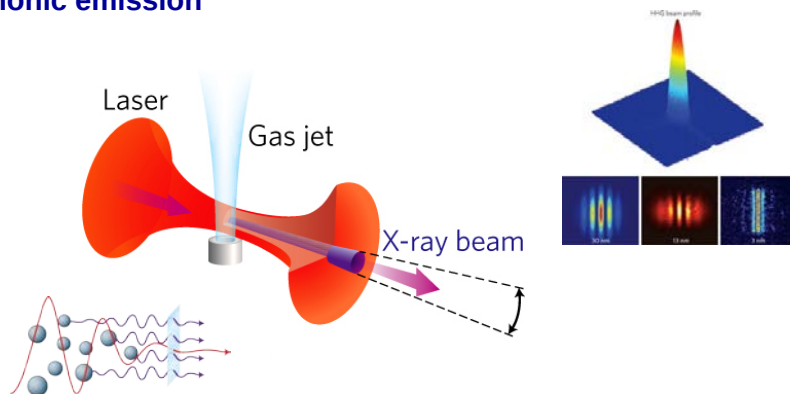


## 2D electron wavepacket quantum simulation



Source: Luis Plaja, U Salamanca

## Macroscopic phase-matched harmonic emission

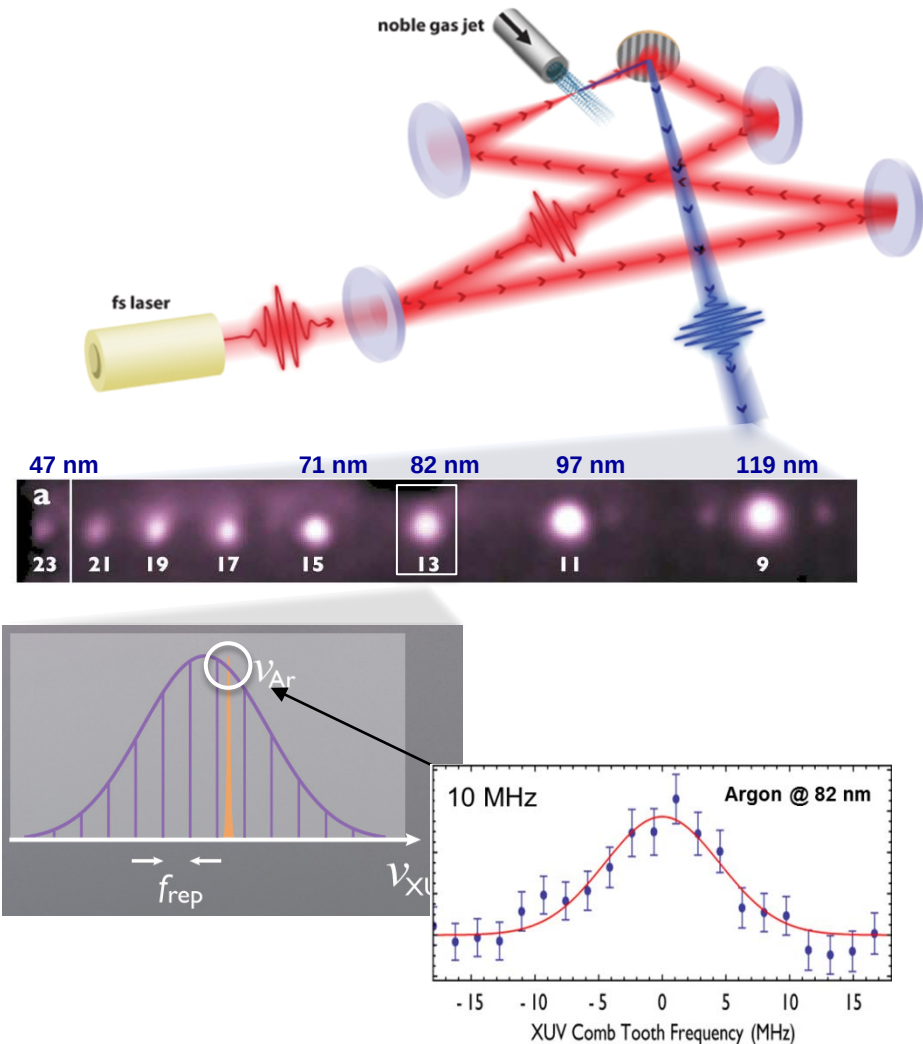




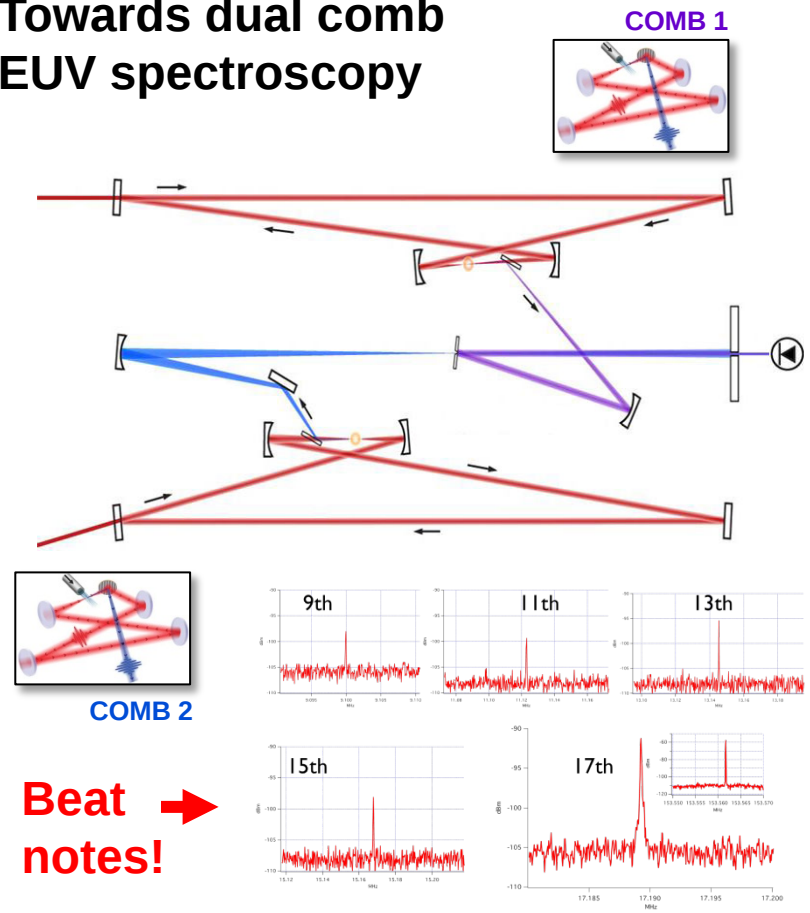
# Direct Frequency Comb Spectroscopy in the Extreme Ultraviolet



PI: Jun Ye, U of Colorado



## Towards dual comb EUV spectroscopy



Unpublished





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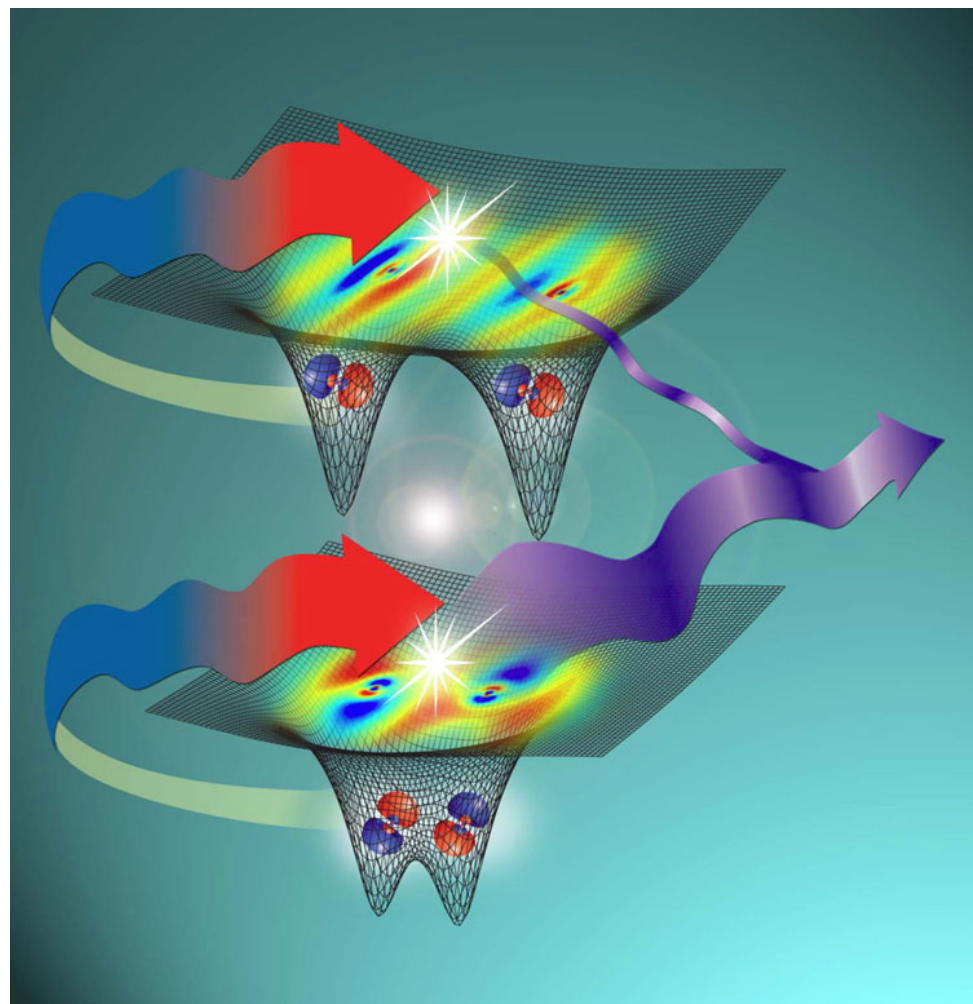
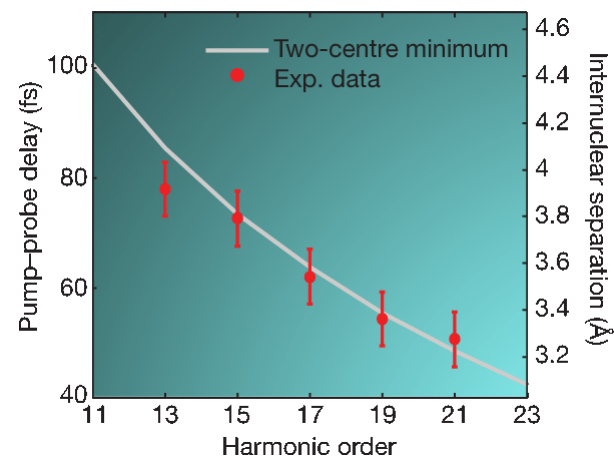
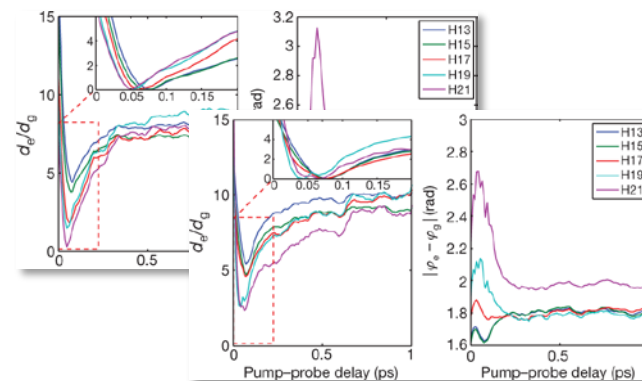
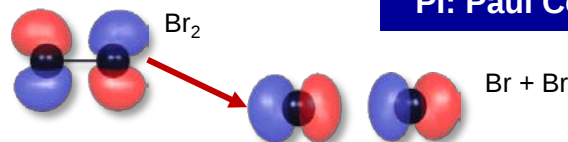
— Relativistic optics



# High Harmonic Interferometry to follow chemical reactions



PI: Paul Corkum, NRC

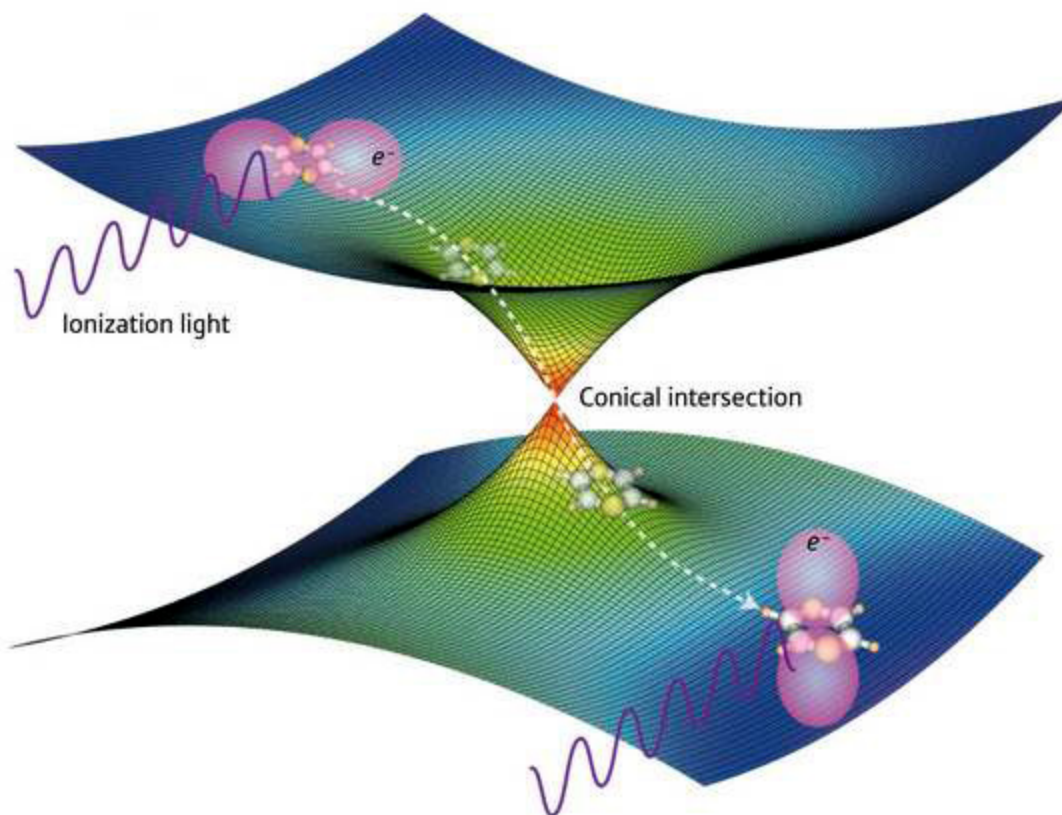




# Conical intersections drive the chemistry of complex molecules



PI: Paul Corkum, NRC

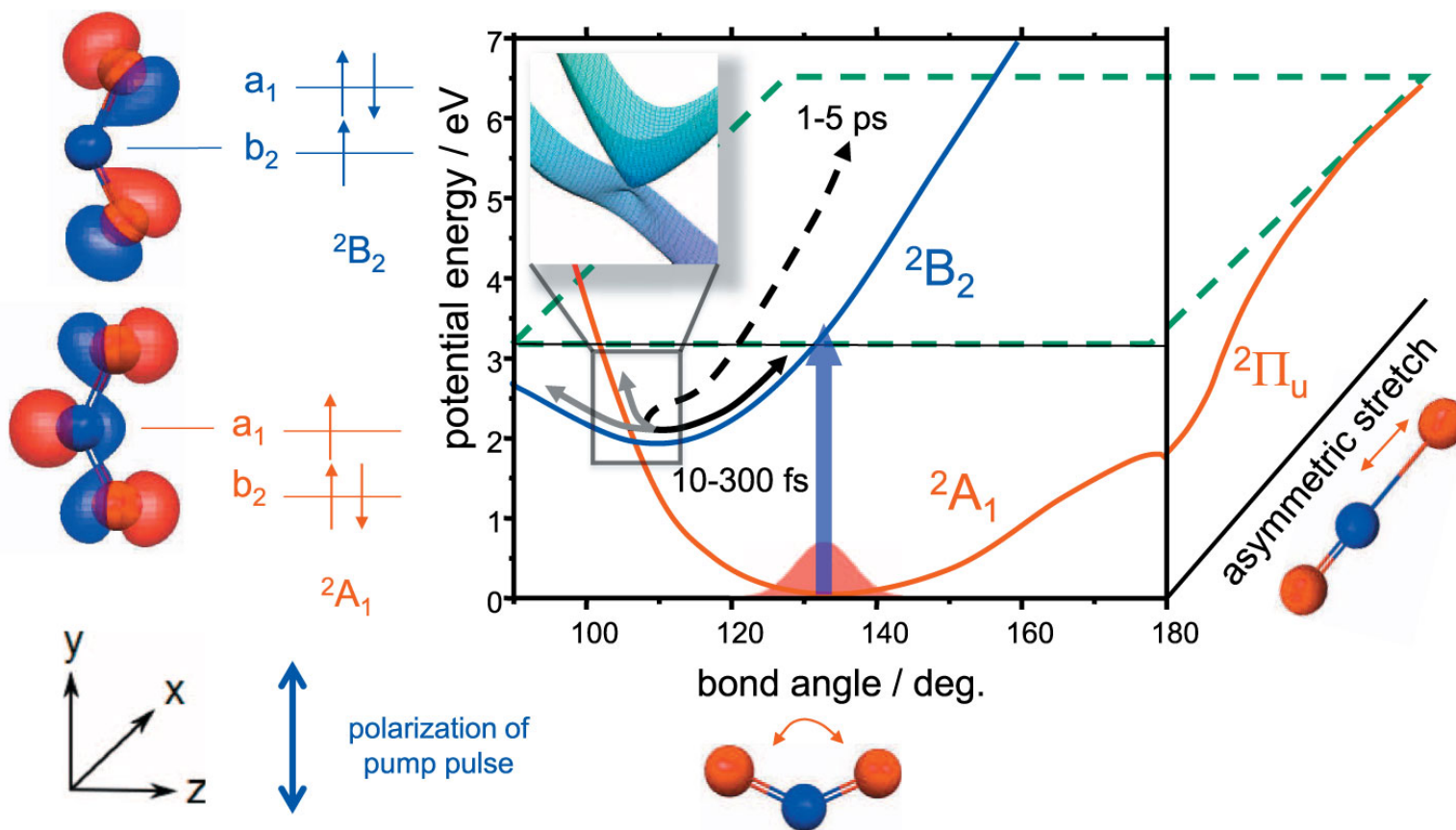




# Conical Intersection Dynamics in NO<sub>2</sub>



PI: Paul Corkum, NRC

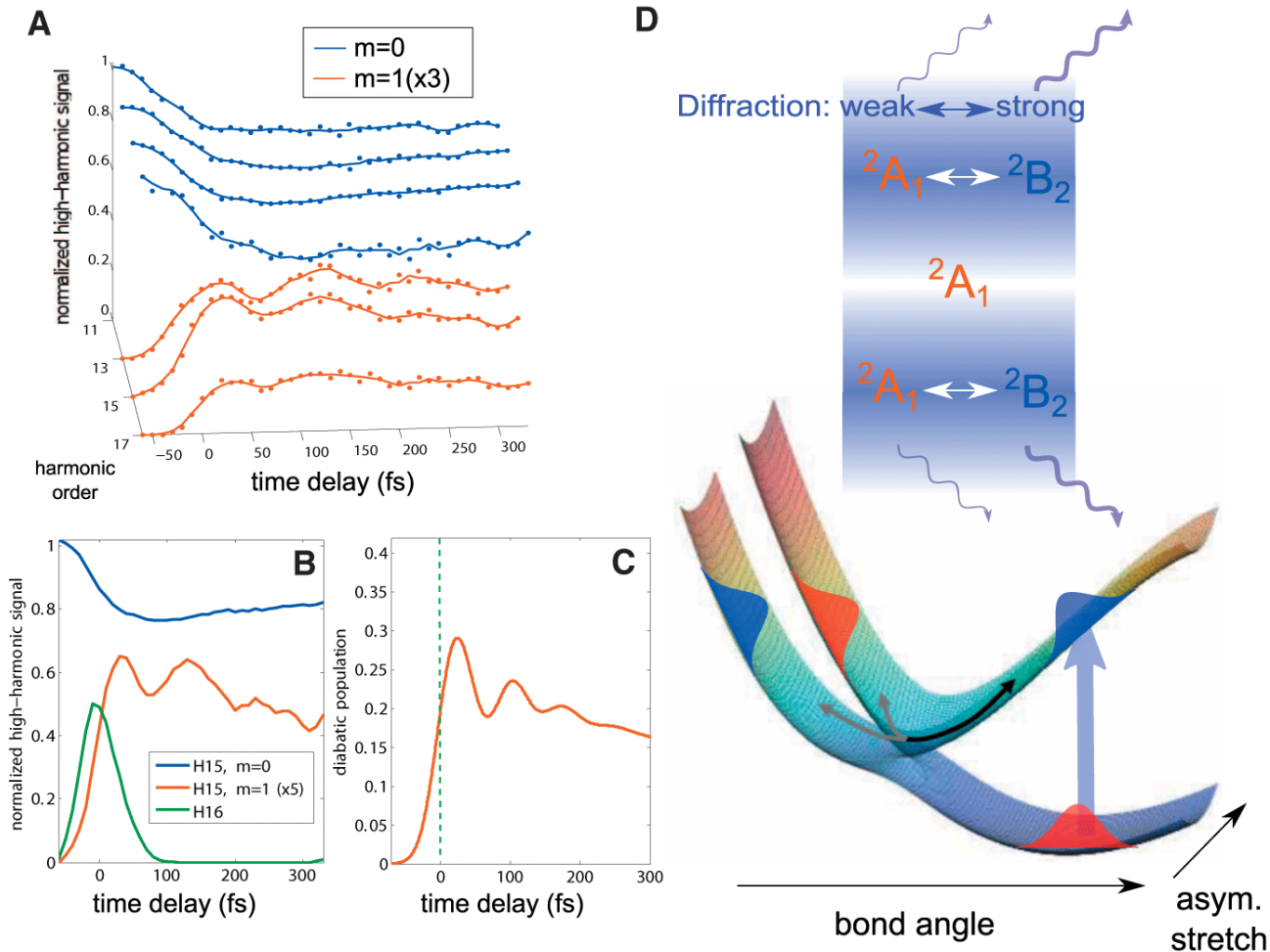




# Electronic dynamics near a conical intersection



PI: Paul Corkum, NRC





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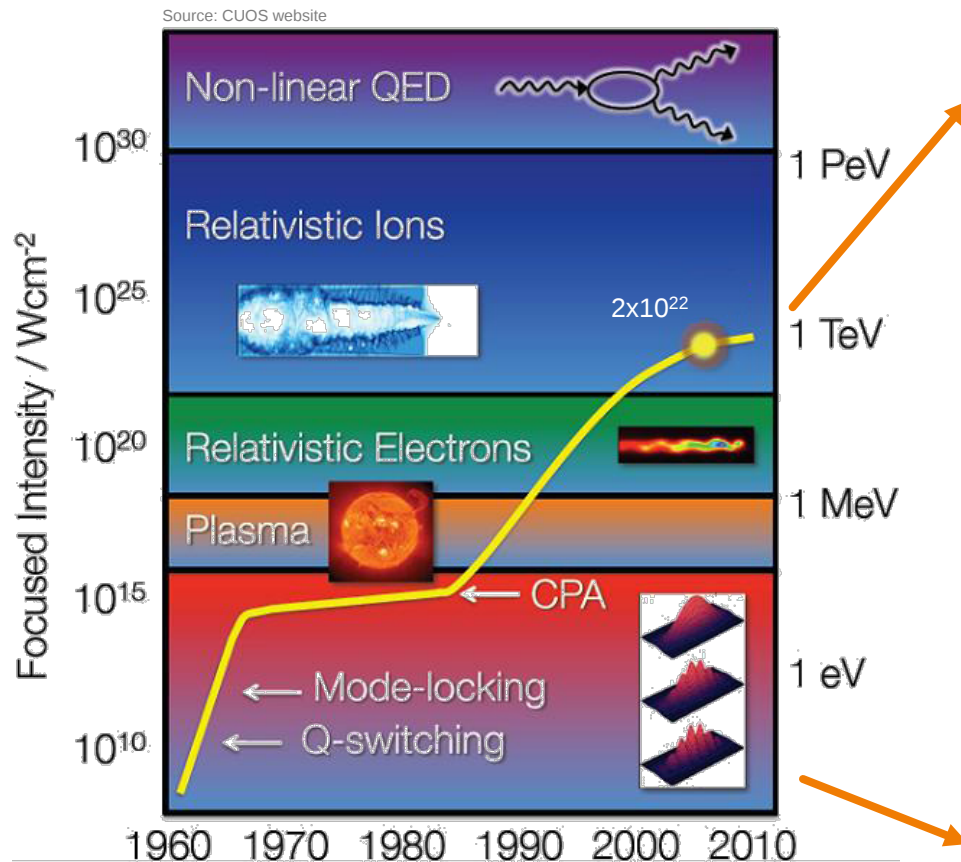


— **Relativistic optics**



# Progress in peak intensity

- Over the last two decades, a 6 order of magnitude increase in achieved focused intensities in table-top systems.



Relativistic ions  
Nonlinearity of vacuum

GeV e acceleration  
e<sup>+</sup>e<sup>-</sup> production  
Nuclear reactions

Relativistic plasmas  
Hard x-ray generation

Tunnel ionization  
High temperature plasma formation  
Bright x-ray generation

Nonperturbative atomic physics  
High order nonlinear optics

Perturbative atomic physics  
Nonlinear Optics



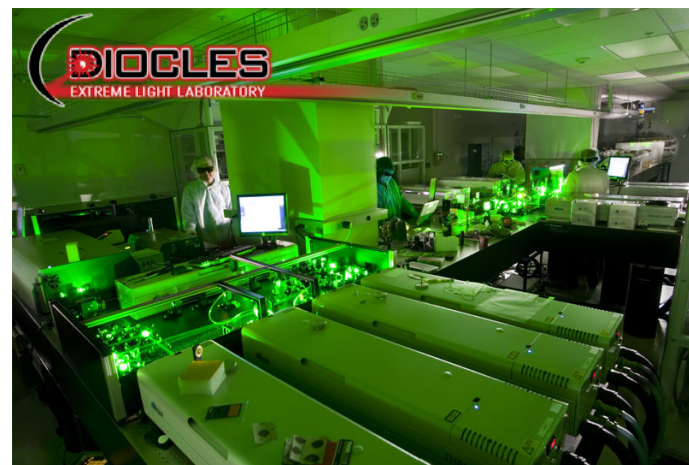
# Petawatt class university lasers



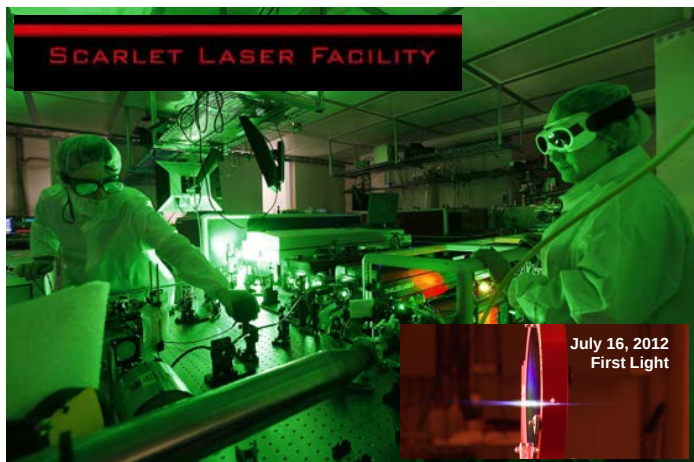
University of Texas, 1.1 PW



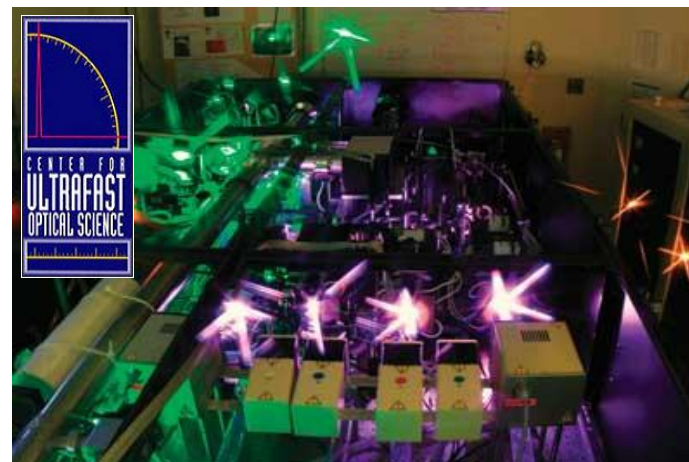
University of Nebraska, 0.7 PW



Ohio State University, 0.5 PW



University of Michigan, 0.3 PW





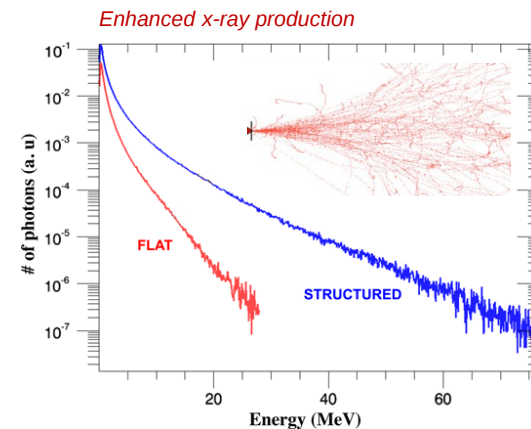
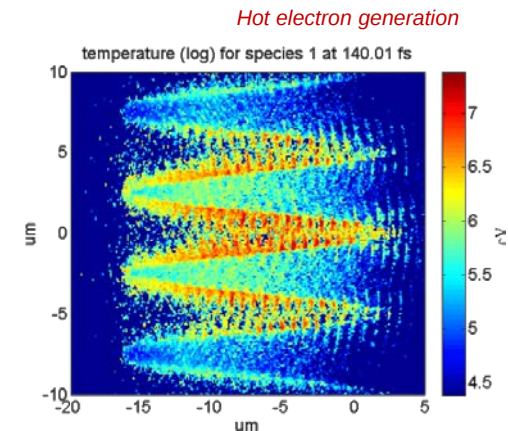
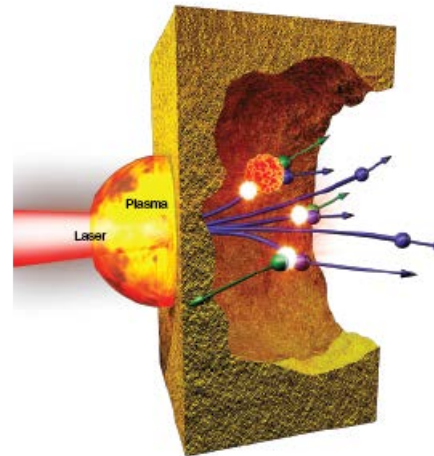
# Laser-driven x-ray sources



Picture: Courtesy of Kwei-Yu Chu and  
Lawrence Livermore National Laboratory

PI: Kramer Akli, OSU

- Understanding laser-generated electron beam characteristics is the key to advancing x-ray sources.
- PIC simulations of high intensity short pulse laser interacting with structured targets yields an enhancement in the number and energy of hot electron.
- Monte Carlo simulations using the electron beam source from PIC show enhancement of x-ray production.



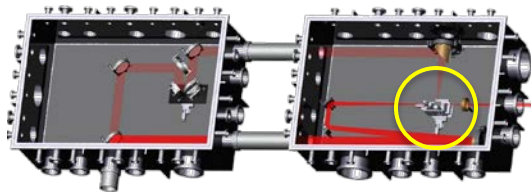


# Laser-driven x-rays generation (0.1 – 10 MeV)

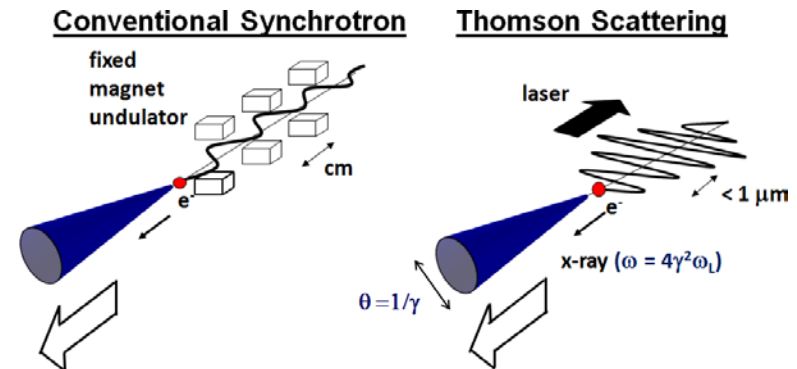
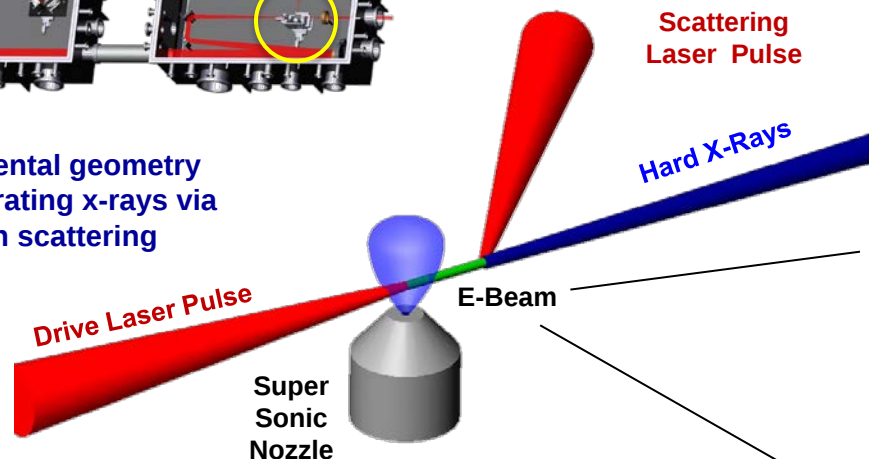


PI: Donald Umstadter, U of Nebraska

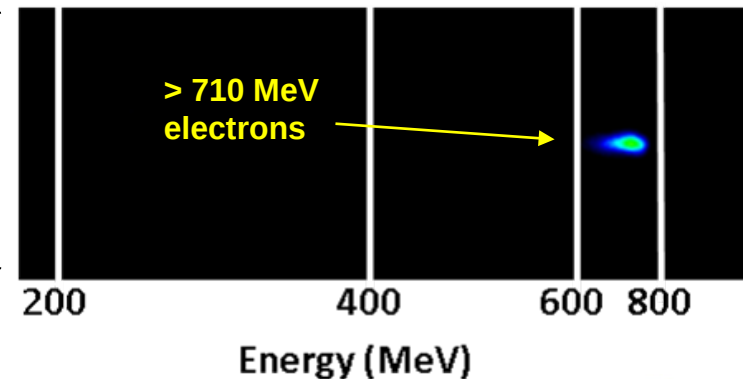
- Scattering from a 300 MeV electron beam can Doppler shift a 1-eV energy laser photon to 1.5 MeV energy.
- Demonstrated > 710 MeV electron beams with no detectable low-energy background.



Experimental geometry for generating x-rays via Thomson scattering



Energy tunability from 0.1 – 0.8 GeV.  
Monoenergetic:  $\Delta E/E \sim 10\%$   
Low angular divergence: 1-5 mrad

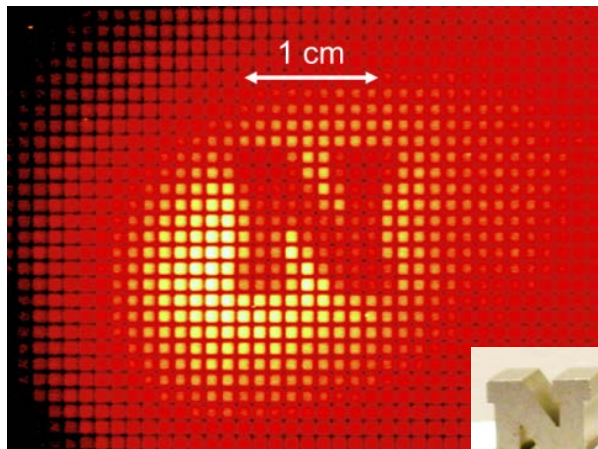
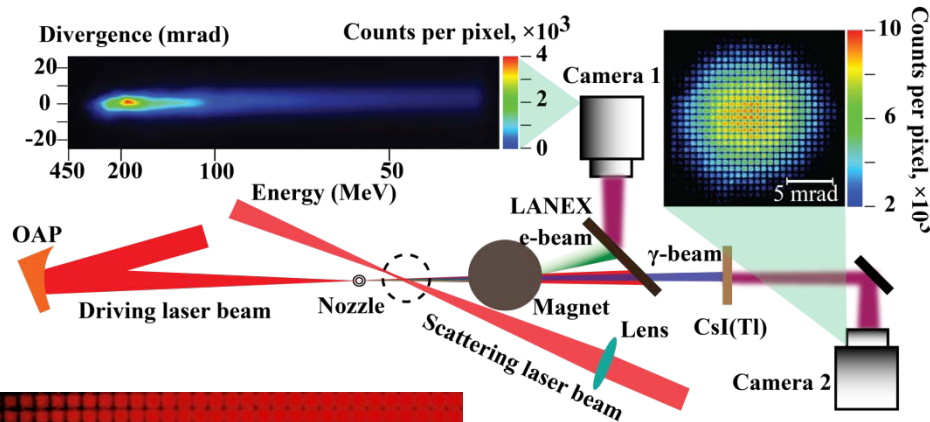




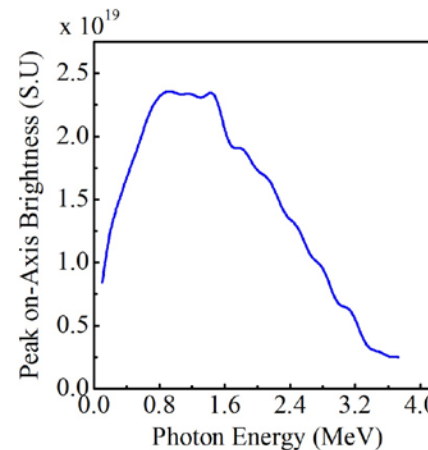
# Laser-driven x-rays generation (0.1 – 10 MeV)



PI: Donald Umstadter, U of Nebraska



0.5 inch thick steel plate



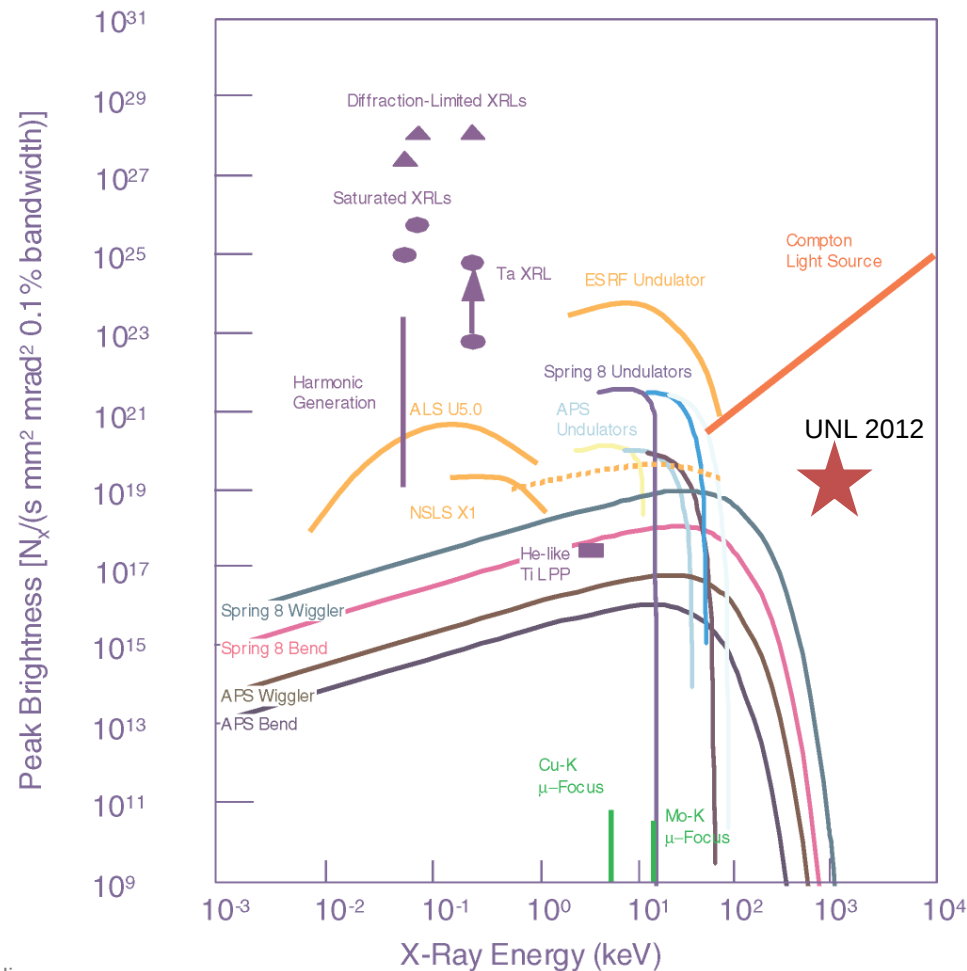
| Beam       | Parameter                          | Sym                | Value                                                                    |
|------------|------------------------------------|--------------------|--------------------------------------------------------------------------|
| $\omega_0$ | Energy                             | $E_{\text{laser}}$ | 0.5 J/ pulse                                                             |
|            | Wavelength                         | $\lambda$          | 800 nm                                                                   |
|            | Pulse duration                     | $\tau_s$           | 90 fs (FWHM)                                                             |
|            | Spotsize                           | $\sigma_L$         | $9.4 \pm 0.4 \mu\text{m}$ (RMS)                                          |
|            | Number of laser oscillations/pulse | $N_{\text{laser}}$ | 34                                                                       |
|            | Average power                      | $P_L$              | 5.6 TW                                                                   |
|            | Normalized field strength          | $a_0$              | 0.4                                                                      |
|            | Photon energy                      | $E_L$              | 1.5 eV                                                                   |
|            | Interaction angle                  | $\Phi$             | 170 deg                                                                  |
|            | Source size                        | $\sigma_e$         | $6.0 \pm 2.6 \mu\text{m}$ (RMS)                                          |
| $e$        | Cutoff energy <sup>i</sup>         | $E_c$              | 250 MeV                                                                  |
|            | Divergence <sup>ii</sup>           | $\theta_e$         | 5 mrad (FWHM)                                                            |
|            | Total charge                       | $Q$                | 120 pC                                                                   |
|            | Source size                        | $\sigma_\gamma$    | $5.1 \pm 2.6 \mu\text{m}$ (RMS)                                          |
| $\gamma$   | Divergence                         | $\theta_\gamma$    | 12.7 mrad (FWHM)                                                         |
|            | Peak energy                        | $E_\gamma$         | 1.2 MeV                                                                  |
|            | Total photon number/pulse          | $N_\gamma$         | $\sim 10^7$                                                              |
|            | Peak on-axis brilliance            | $B_s$              | $2.3 \times 10^{19}$ photons/s-<br>$\text{mm}^2\text{-mrad}^2$ (0.1% BW) |



# Brighter, more energetic and tunable than conventional synchrotrons



PI: Donald Umstadter, U of Nebraska



Hartemann, F. V. et al. High-energy scaling of Compton scattering light sources. Physical Review Special Topics - Accelerators and Beams 8, 100702 (2005).

DISTRIBUTION A: Approved for public release; distribution is unlimited

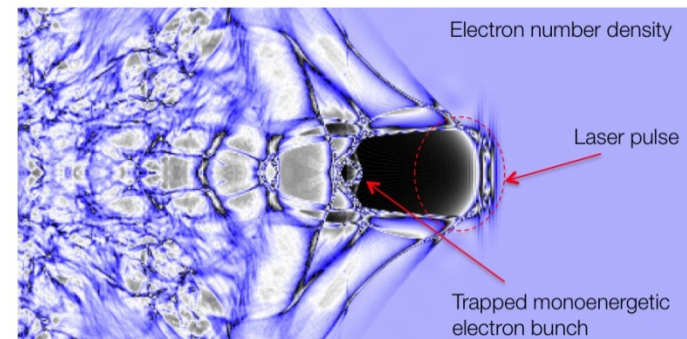




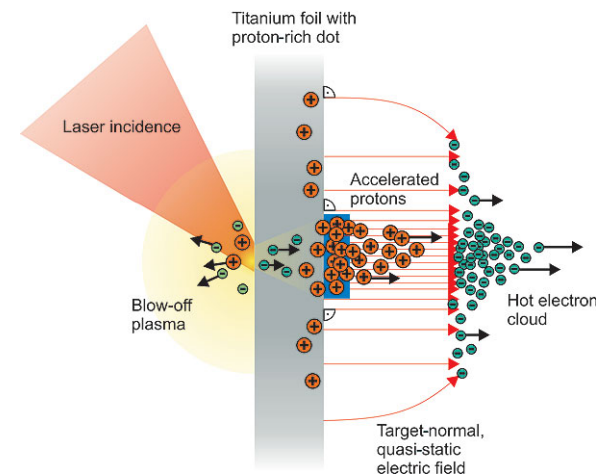
# (FY14 BRI) Laser-matter interactions in the relativistic optics regime



- **Laser-driven electron acceleration**
  - Laser Wakefield Acceleration: Electrons are accelerated to gigaelectronvolt (GeV) energies over centimeters distances
  - Direct Light Acceleration
- **Ion acceleration**
  - Protons and ions are accelerated to megaelectronvolt (MeV) energies by a mechanism known as ‘target normal sheath acceleration’ (TNSA)
- **X-ray radiation sources**
  - keV to MeV x-rays via non-linear Thomson Scattering
  - K $\alpha$  monochromatic emission
  - Bremsstrahlung broadband radiation
- **Neutron sources**
  - Protons incident on a secondary target (e.g. Lithium) can produce MeV neutrons
- **QED physics**



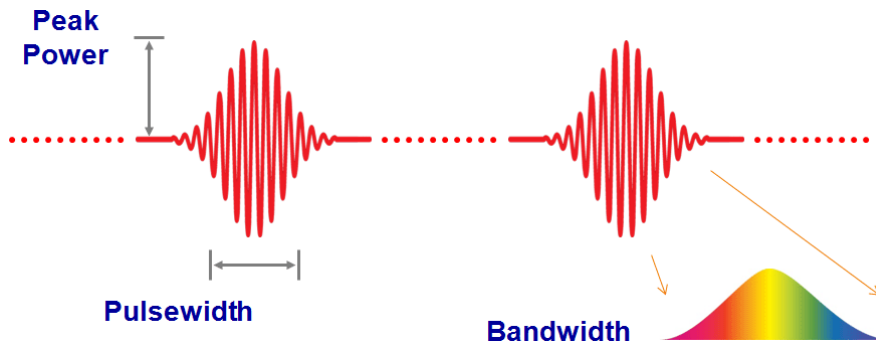
*Electron density distribution and generation of quasi-monoenergetic electron bunches observed in PIC simulations.*



*Target Sheath Normal Acceleration: Laser acceleration of protons from the back side of a microstructured target.*



# Summary and outlook



The program aims to understand and control light sources exhibiting extreme temporal, bandwidth and peak power characteristics.

## Optical frequency combs

*ultra-wide bandwidths*

- Spectral coverage to exceed an octave with high power/comb.
- Coherence across EUV-LWIR.
- Novel resonator designs (e.g. micro-resonator based).
- Ultra-broadband pulse shaping.
- ...

## High-field laser physics

*high peak powers*

- Laser-solid interactions.
- Fs propagation in media.
- Sources of secondary photons.
- Compact particle accelerators.
- High peak power laser architectures.
- High repetition rates.
- New wavelengths of operation.
- ...

## Attosecond science

*ultrashort pulsewidths*

- Efficient, high-flux generation.
- Pump-probe methods.
- Probe atoms/molecules & condensed matter systems.
- Attosecond pulse propagation.
- Novel attosecond experiments.
- Fundamental interpretations of attosecond measurements.
- ...